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concept
for a
reflectometer
using
focusing guides



Selene

TUM & FRM II seminar
12. 03. 2012, München, Germany

outline

reflectometry

- principle
- examples

slit optics vs. focusing optics

small samples

focusing with elliptic guides

- coma aberration
- operation modes

realisation

- add-on for Amor → experimental results
- 2D prototype for BOA
- concept for the ESS

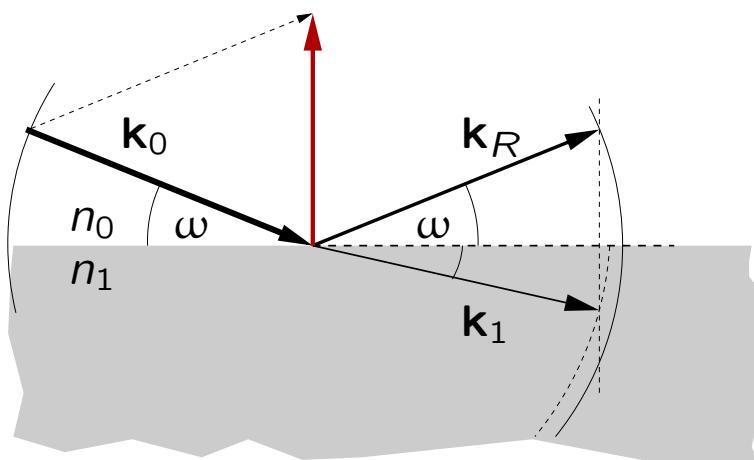
reflectometry

reflectometry



analogy to visible light:

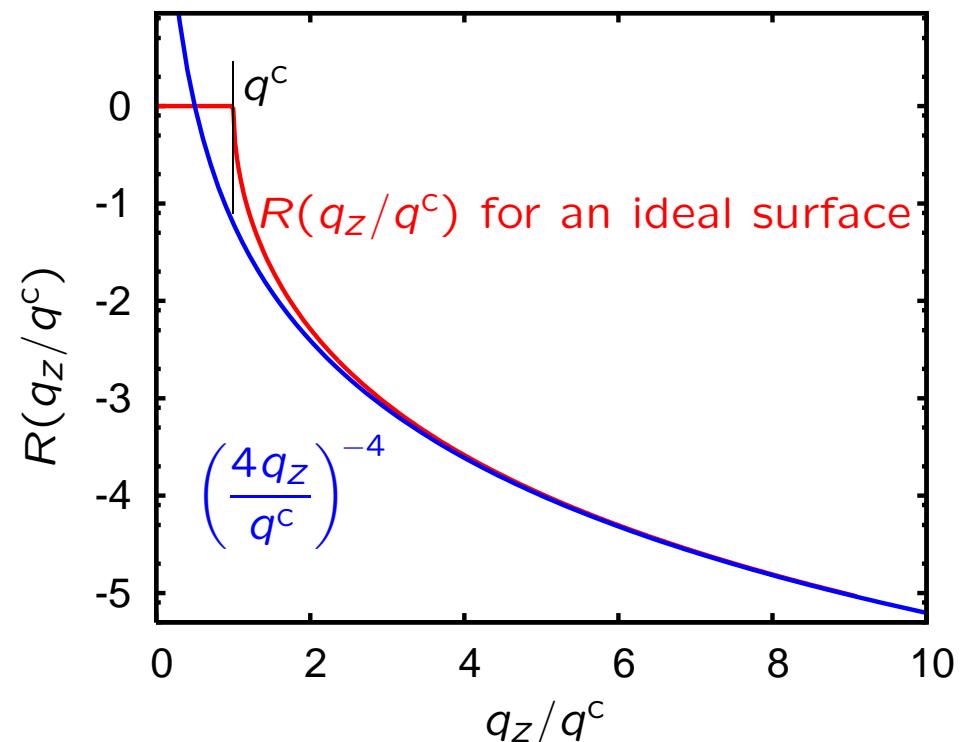
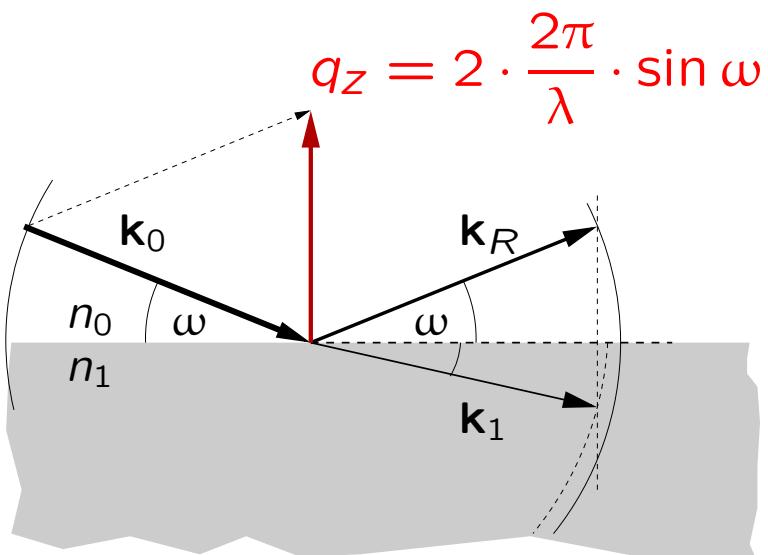
- flat surfaces partly reflect light
- some media also transmit light
- parallel interfaces ⇒ interference



reflectometry

Fresnel reflectivity

- reflectivity of a sharp flat surface
- total external reflection for $q_z < q^c$
- exponential decay of $R(q_z)$ for $q_z > q^c$



neutrons / x-rays:

$$\lambda \in \{1 \dots 20 \text{ \AA}\}$$

$$\omega^c < 1^\circ$$

reflectometry

reflected intensity of a multilayer

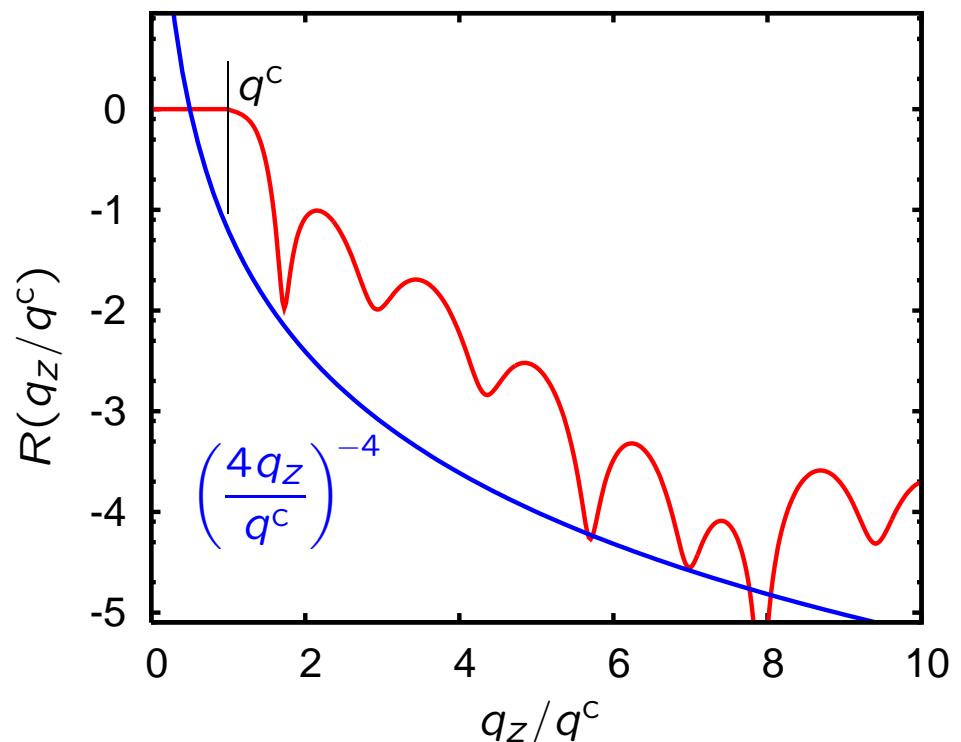
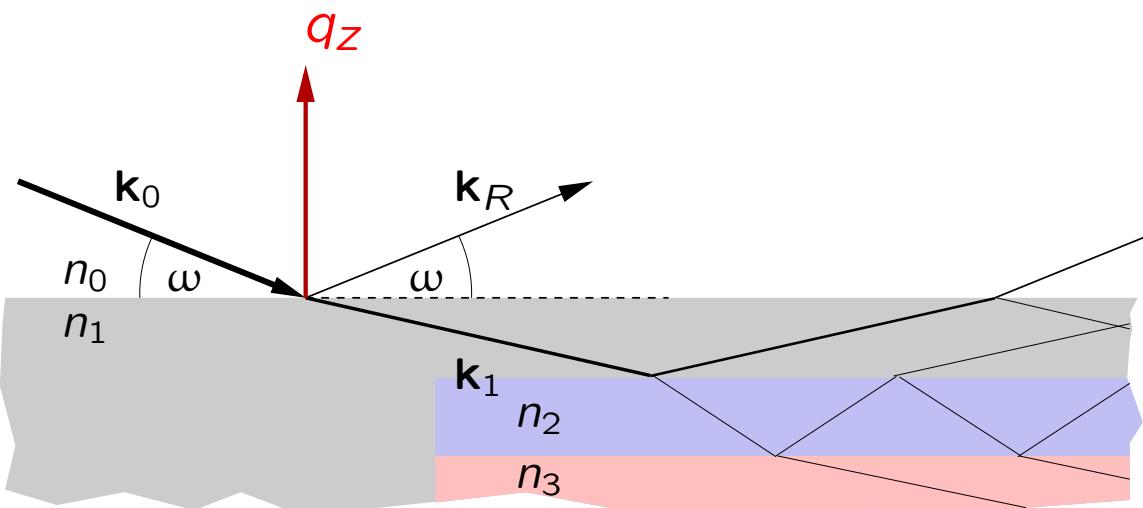
several parallel interfaces:

interference of all waves

⇒ complex reflectance

$$r = r(q_z, n_0, n_1, n_2, \dots, d_1, d_2, \dots)$$

$$R(q_z) = |r(q_z)|^2$$



$$r_{0,1}, t_{0,1}$$

$$r_{1,2}, t_{1,2}$$

$$r_{2,3}, t_{2,3}$$

d_1 thickness of layer 1

d_2 reflectance of interface 2/3

$$d_3$$

reflectometry

reflected intensity of a multilayer

$$R(q_z) = |r(q_z)|^2$$

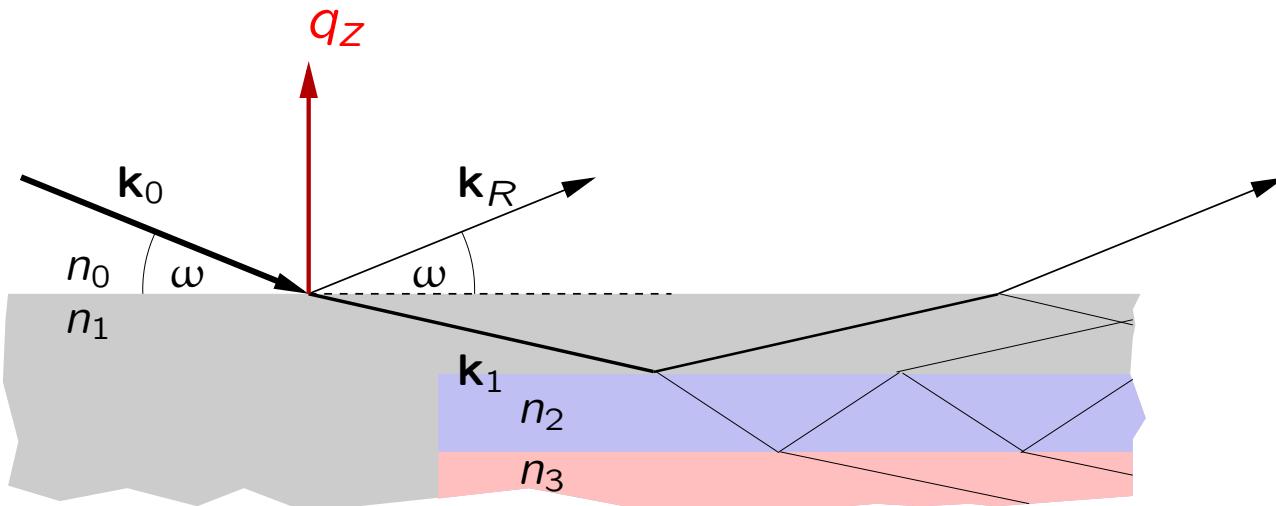
⇒ all phase information is lost

⇒ one way road:

⇒ calculation of $R(q_z)$ using a model

and

comparison to measured curve(s)

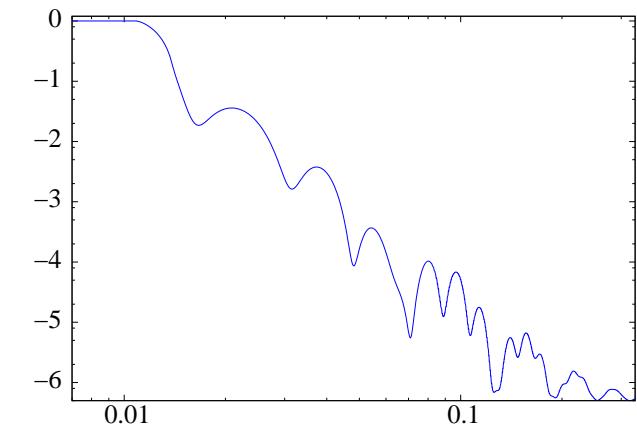
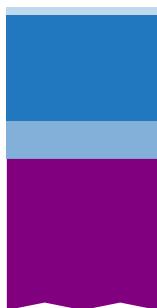
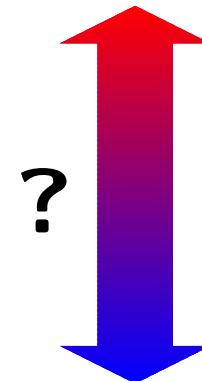
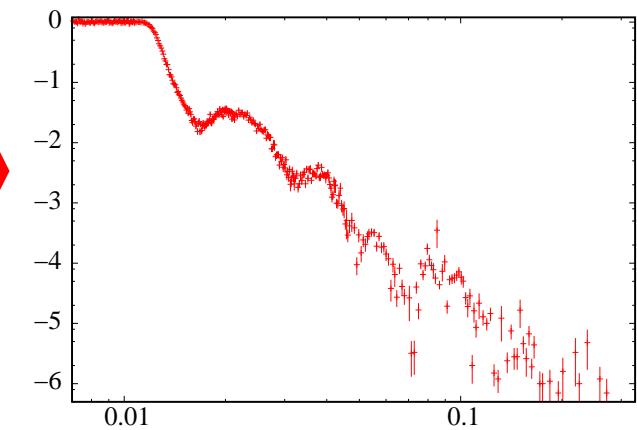


real effects

to be taken into account:

- illumination of the sample
- resolution of the set-up
- $\Delta\omega$, $\Delta\lambda$
- non-sharp interfaces
- inhomogeneous layers

reflectometry



reflectometry

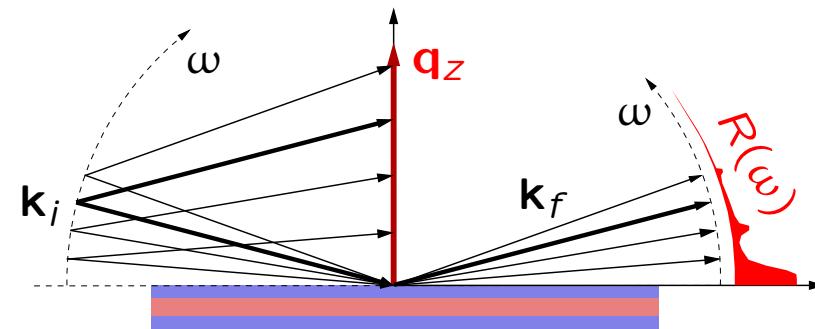
measurement schemes

$$R = R(q_z) = R(\lambda, \omega) \quad q_z = 4\pi \frac{\sin \omega}{\lambda}$$

angle-dispersive set-up

variation of ω with fixed λ

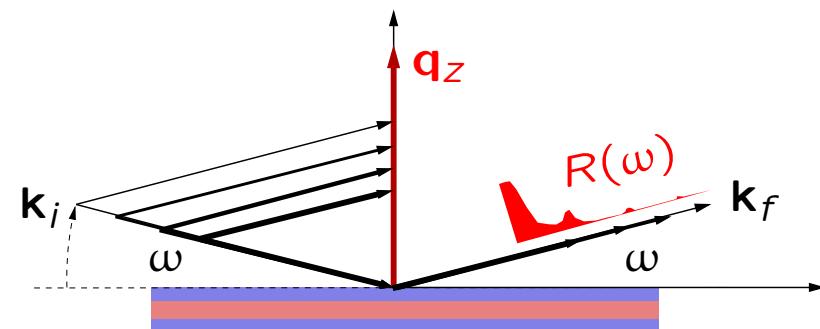
detection under 2ω



energy-dispersive set-up

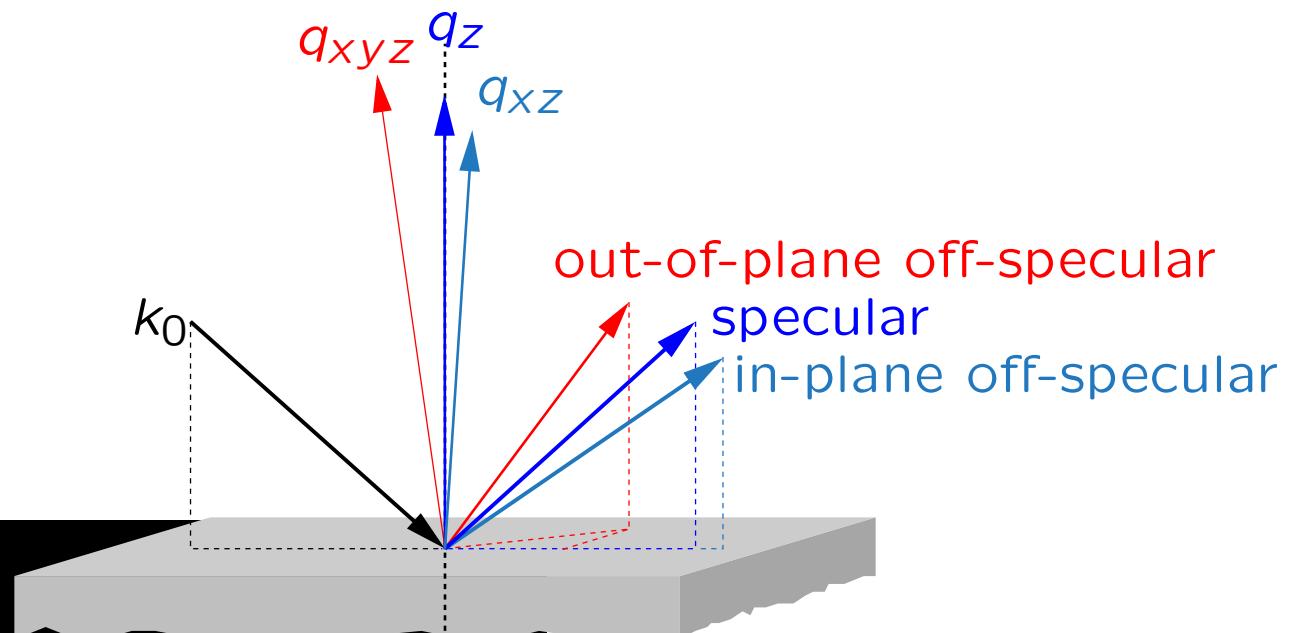
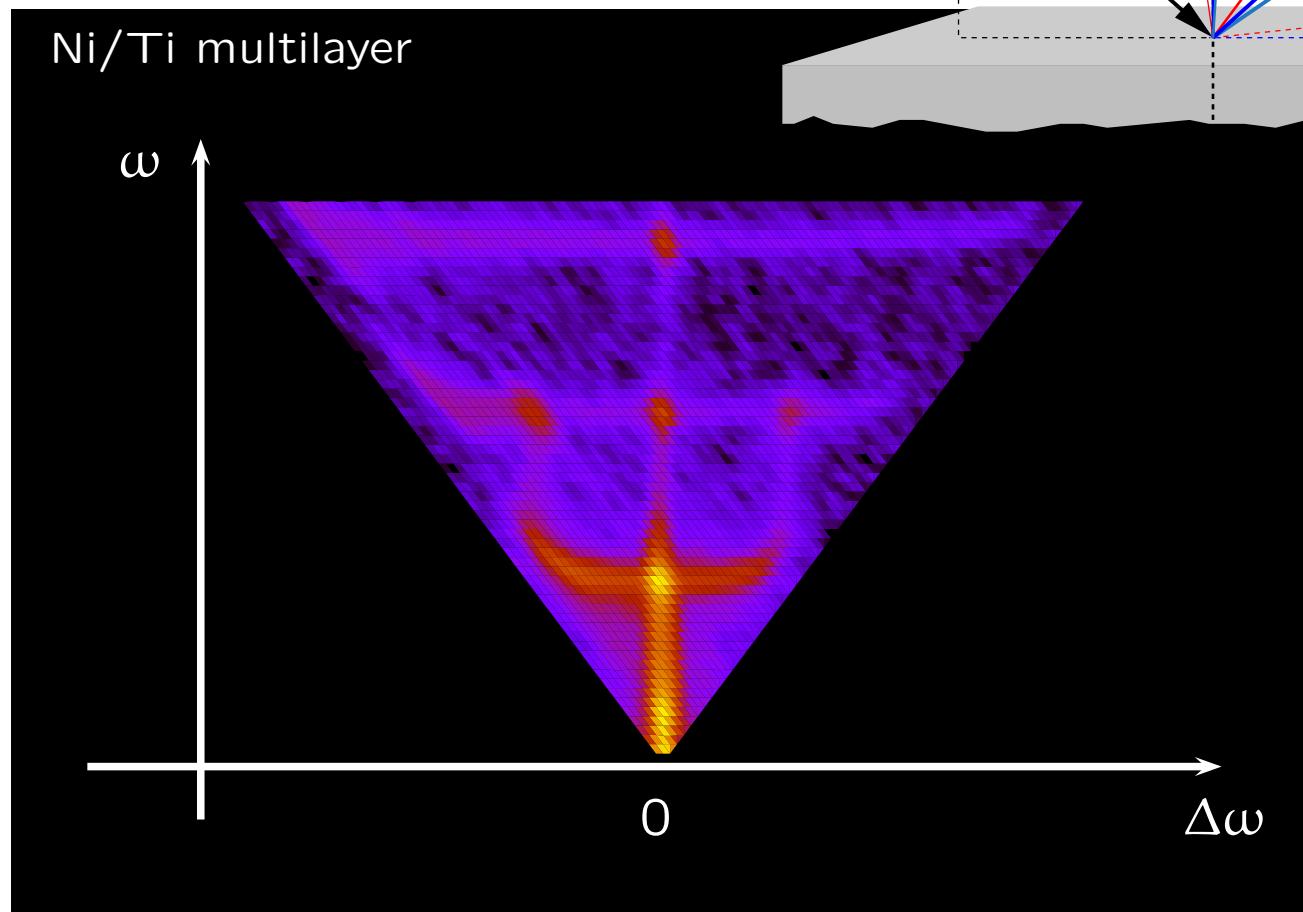
variation of λ with fixed ω

detection via time-of-flight



reflectometry

off-specular scattering



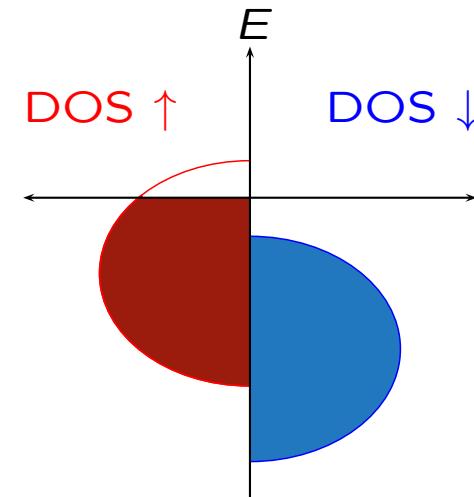
here:
resolution in x : $\approx 0.01^\circ$
resolution in y : $> 1^\circ$
 \Rightarrow integration over y

reflectometry

example: perovskite multilayer



LSMO is a half-metal



⇒ injection of spin-polarised current expected

→ but not found!

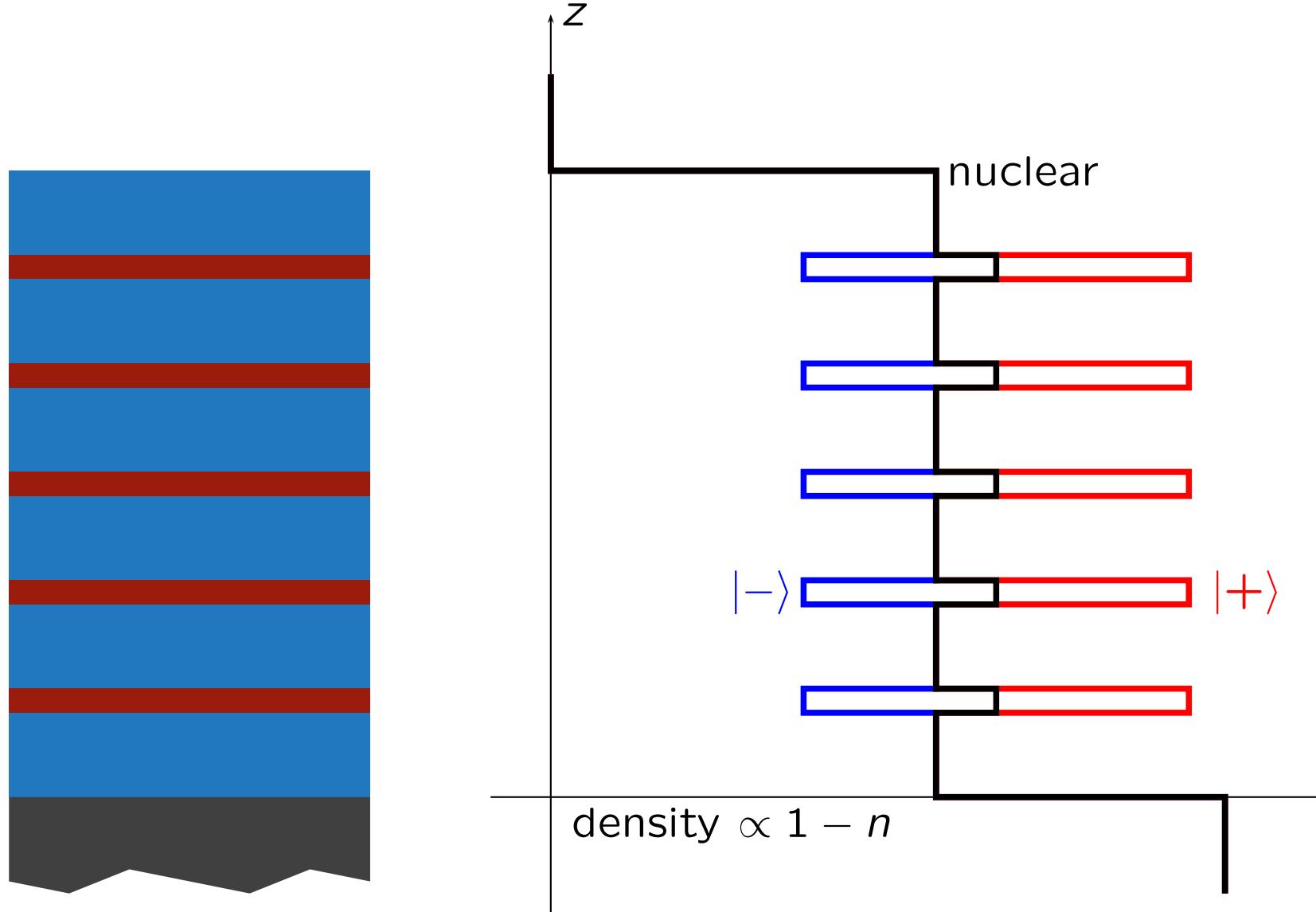
explanation: reduced / suppressed magnetism at interfaces

Is that true?

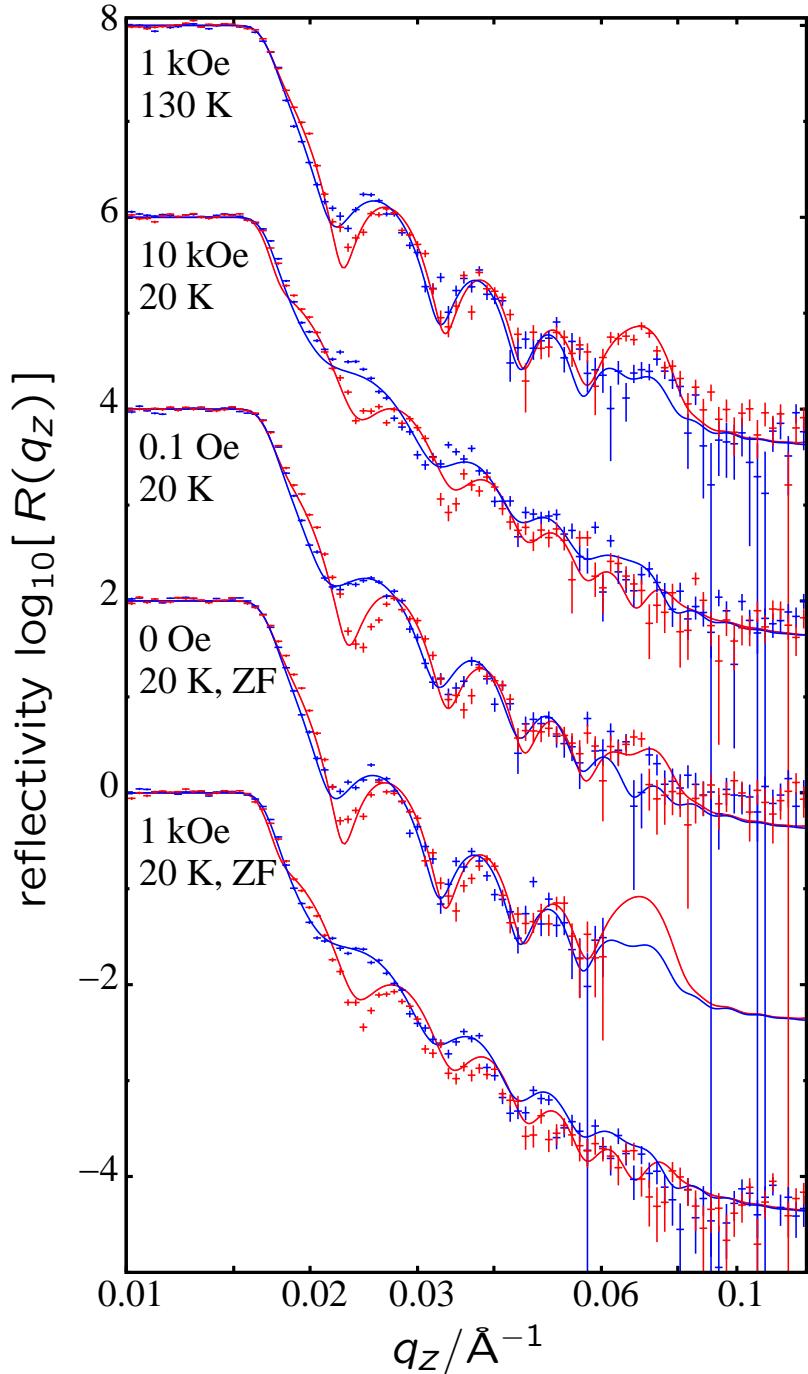
reflectometry

example: perovskite multilayer

by courtesy of C. Aruta and F. Miletto



reflectometry



PCMO

magnetism:

none

full

interfaces

none

interfaces

findings:

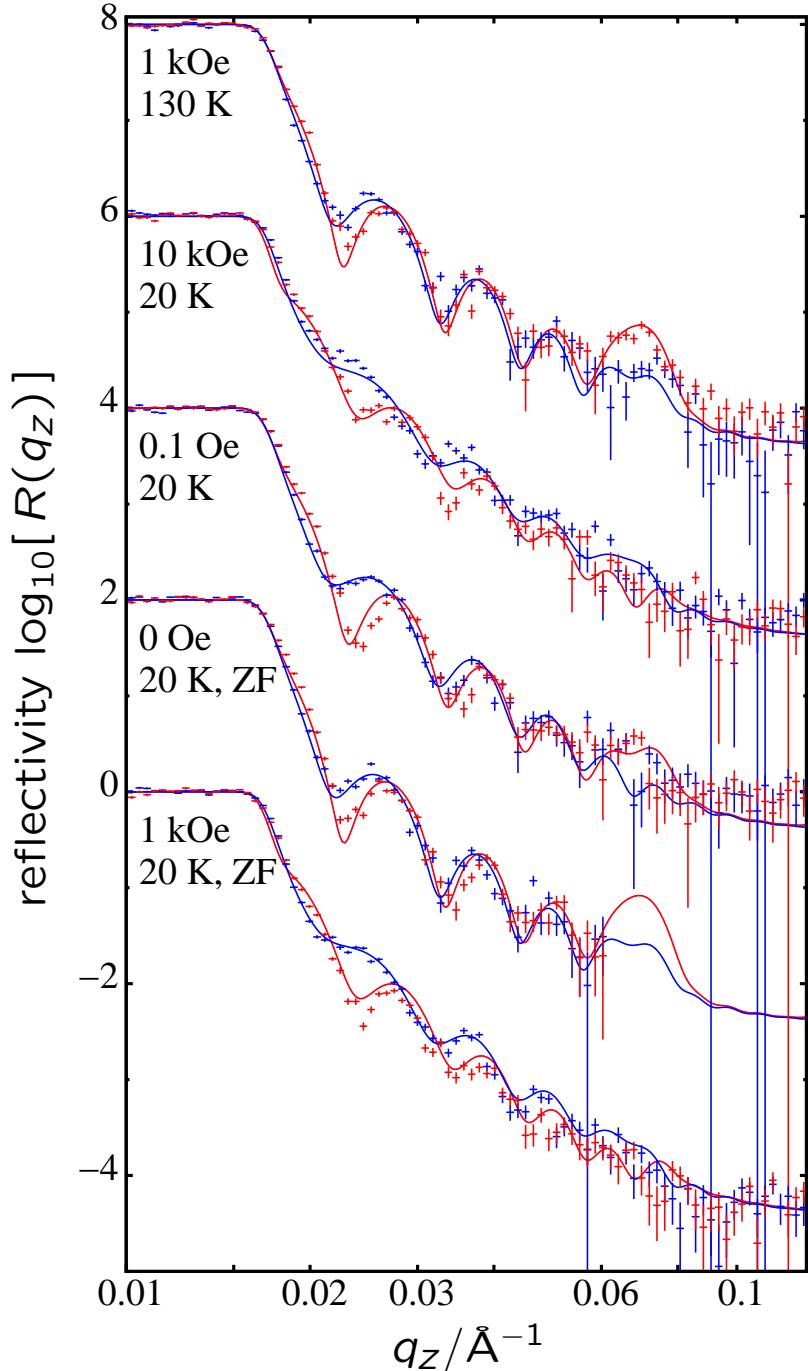
- no reduction of M within LSMO

but

- induced M in PCMO
(already above T_{Curie})

to be continued . . .

reflectometry



sample: $5 \times 5 \text{ mm}^2$



counting time per spin state: 12 h!



accurate screening of H
and T not possible

⋮

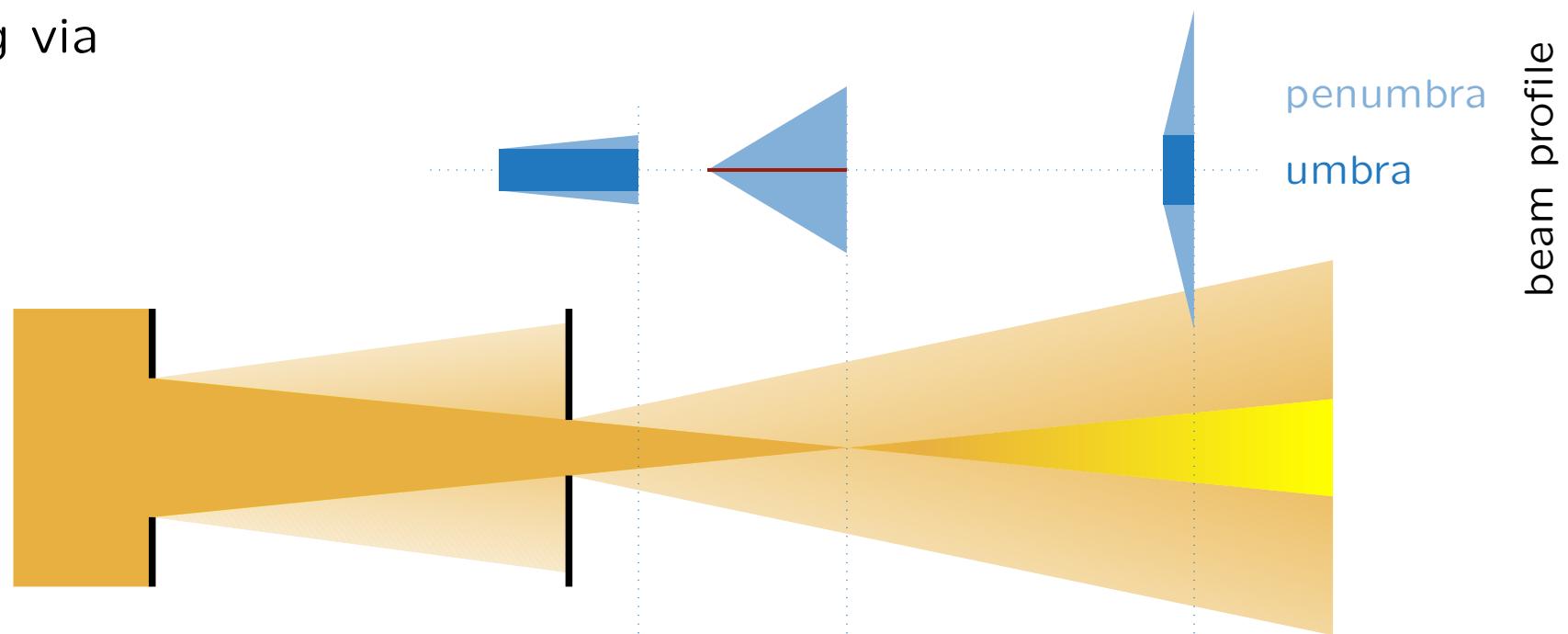
at the moment!

slit vs. focusing optics

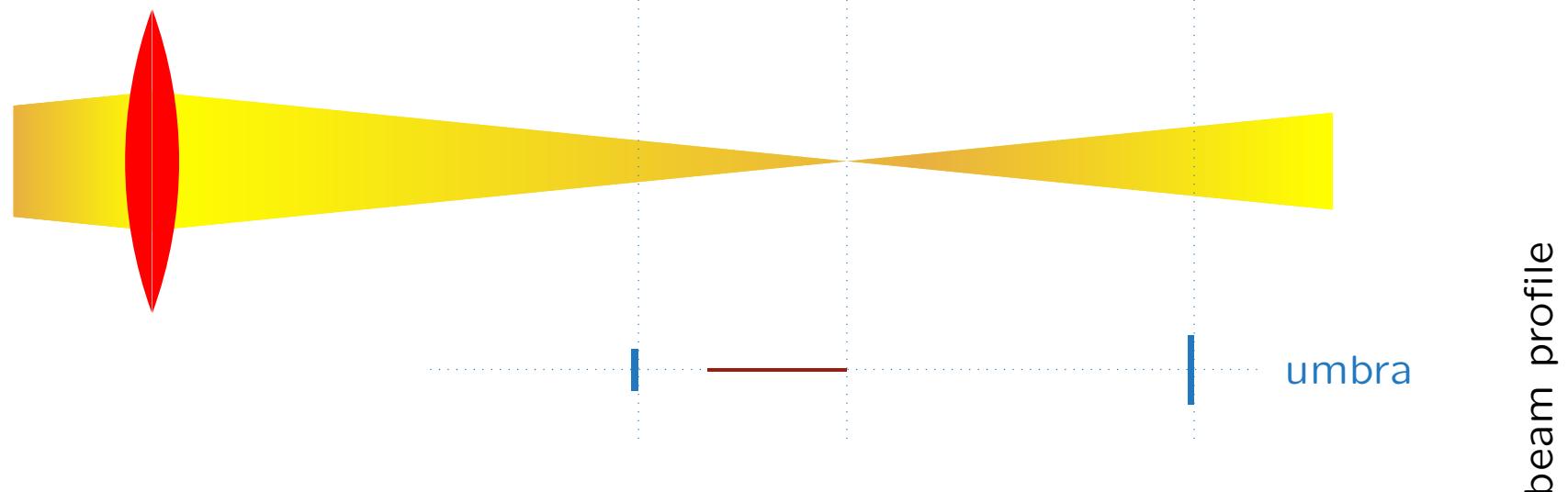
slit vs. focusing optics

focusing via

slits



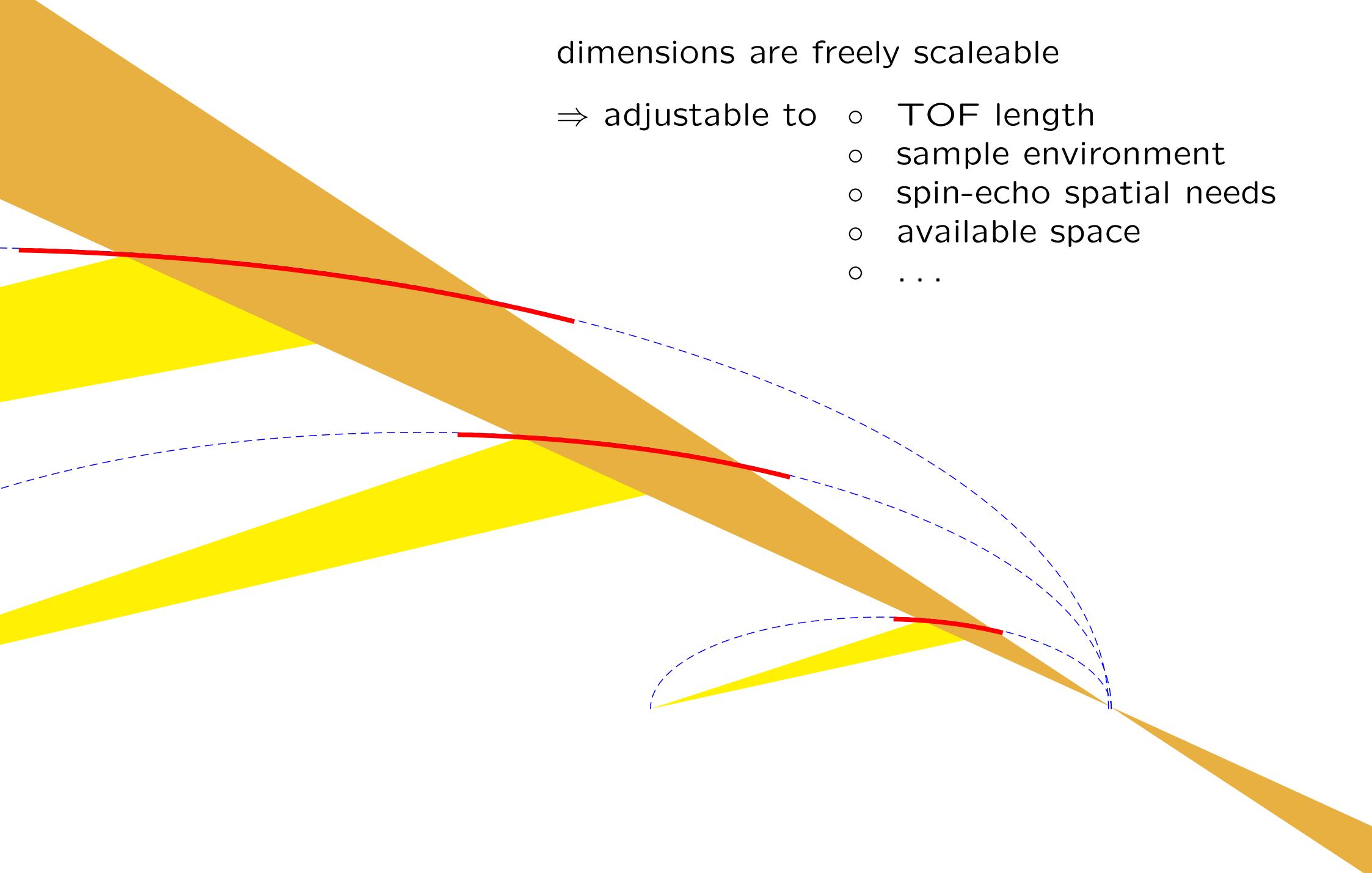
reflective /
refractive optics



dimensions are freely scaleable

⇒ adjustable to

- TOF length
- sample environment
- spin-echo spatial needs
- available space
- ...

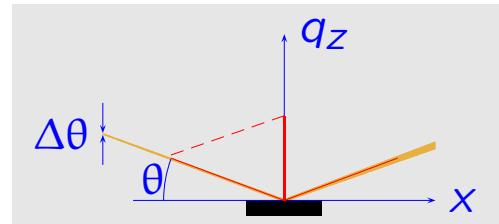


slit vs. focusing optics

focusing for high-flux specular reflectometry

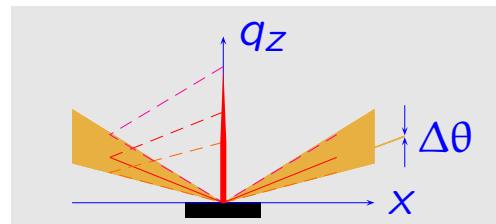
slit-defined beam:

- θ -dispersive, **or**
- λ -dispersive,
- resolution given by $\Delta\lambda$ and $\Delta\theta$



convergent beam:

- θ -dispersive **and**
- λ -dispersive,
- resolution given by $\Delta\lambda$ and detector



small samples

small samples

i.e. **samples smaller than the beam**

- e.g.
- PLD-grown samples
 - laterally structured films
 - functional devices
 - samples compatible with x-ray or magnetometry environments

projected height < 1 mm!

Ni/Ti multilayer on Si, $4 \times 3 \text{ mm}^2$

perovskite multilayer on STO, $5 \times 5 \text{ mm}^2$



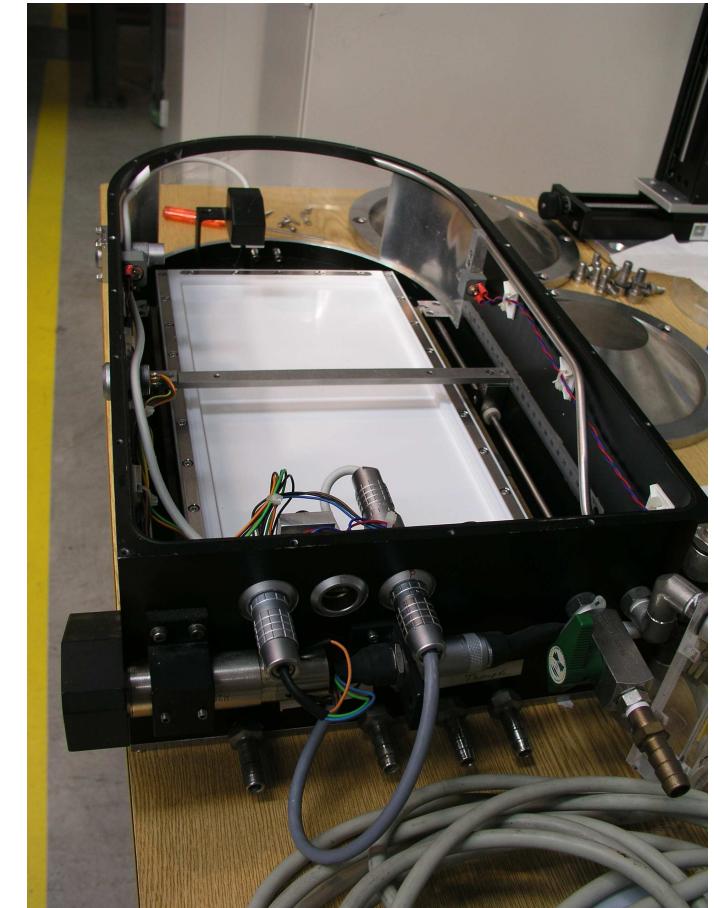
small samples

i.e. **illumination of a defined area, only**

e.g.

- inner region within a LB-trough →

- inner region of a solid-liquid cell
- samples with electrical contacts
- partially coated substrates
- bent substrates



footprint < substrate

typical dimensions: $10 \times 10 \text{ mm}^2$ to $20 \times 40 \text{ mm}^2$

small samples

i.e. **latteraly inhomogeneous samples**

- e.g.
- structured materials
 - samples with (large) domains
 - bent surfaces →



footprint \ll substrate

typical dimensions: $0.1 \times 10 \text{ mm}^2$

⇒ scanning of sample area

focusing with elliptic guides

real focusing!

⇒ pre-image → image

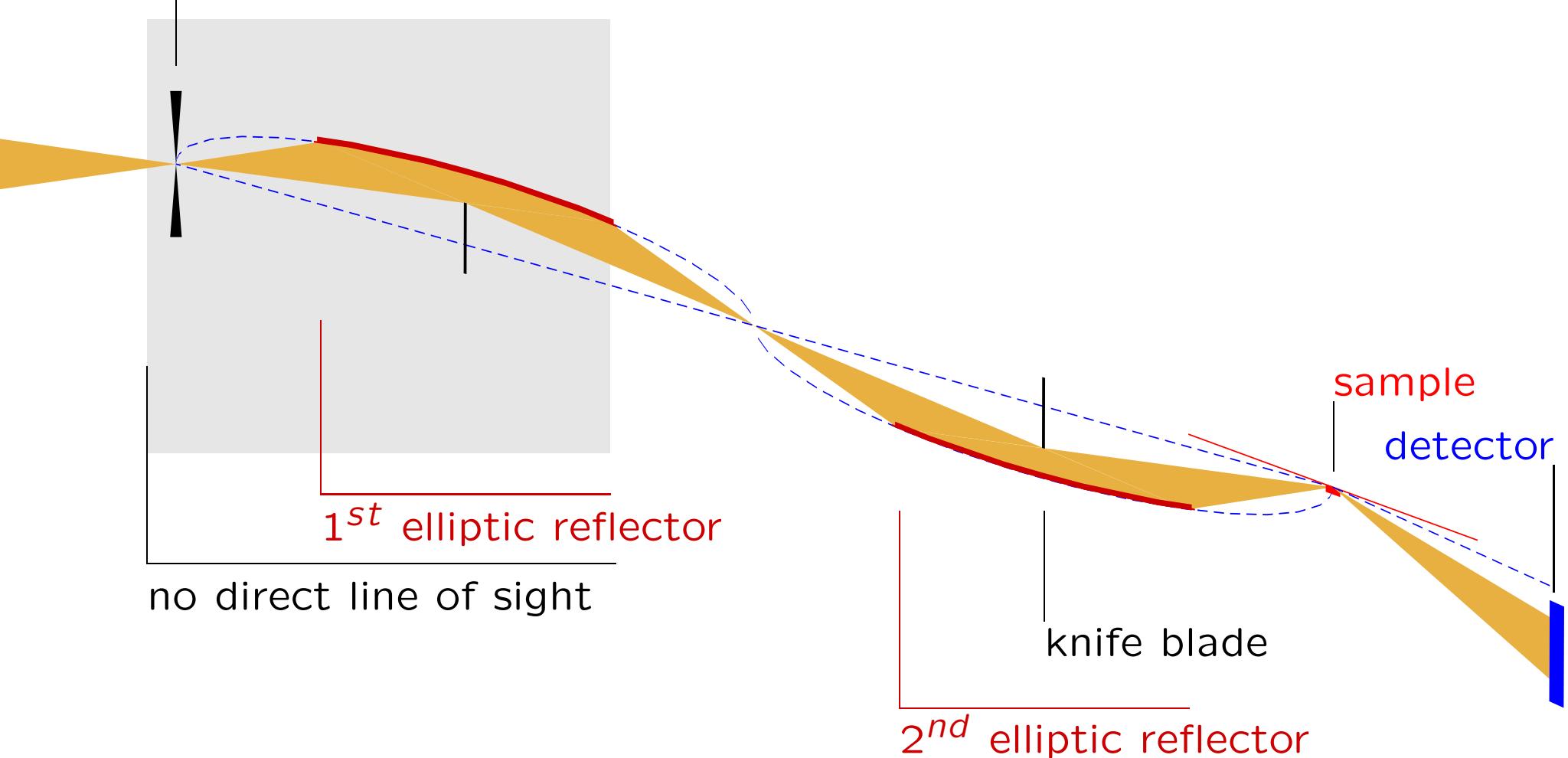
no fancy version of a ballistic guide!

focusing with elliptic guides

generic instrument layout

cut in the scattering plane
stretched by 10 normal to incident beam

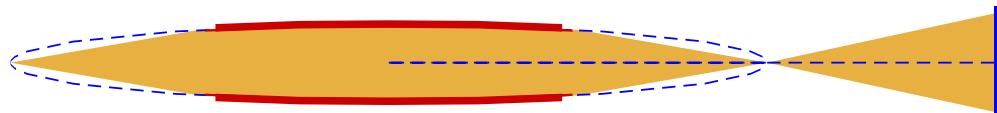
initial slit $\hat{=}$ projected sample size



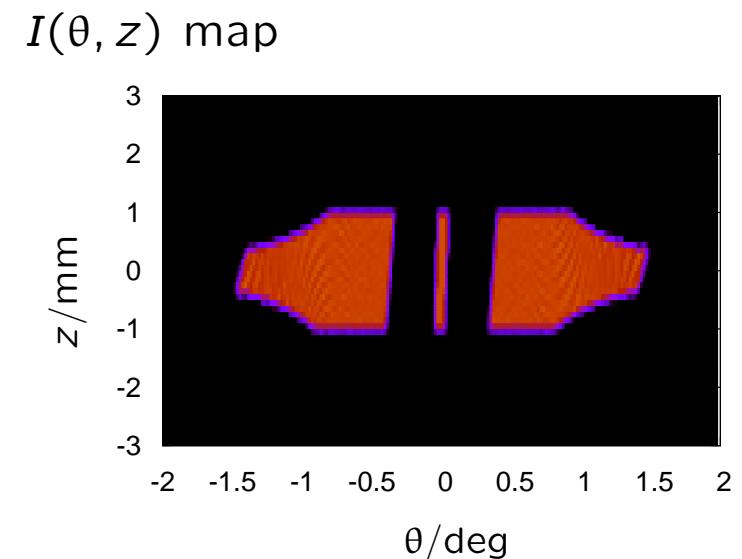
focusing with elliptic guides

why only one branch of an ellipse?

- no structured $I(\theta, z)$



- one branch can cover $\Delta\theta$

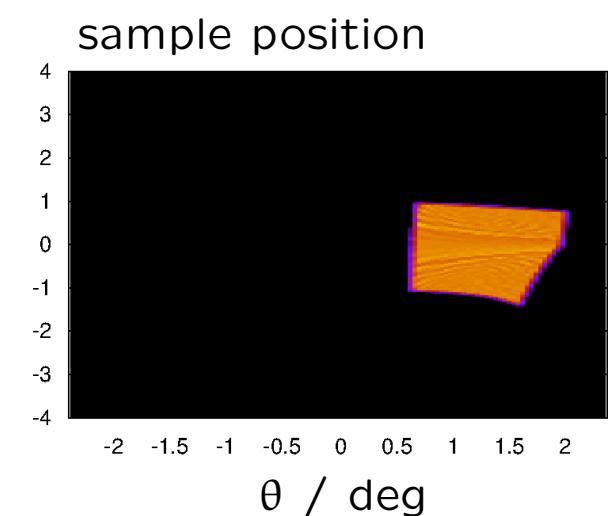
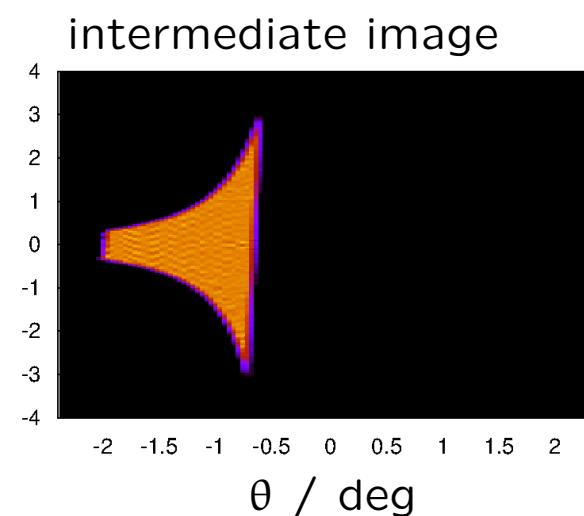
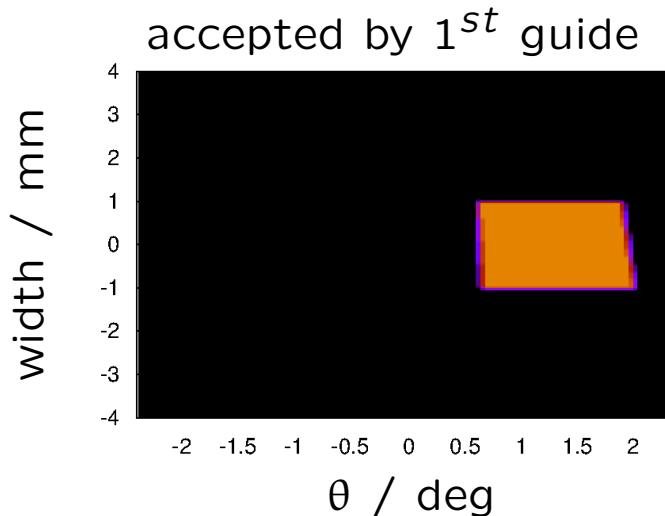
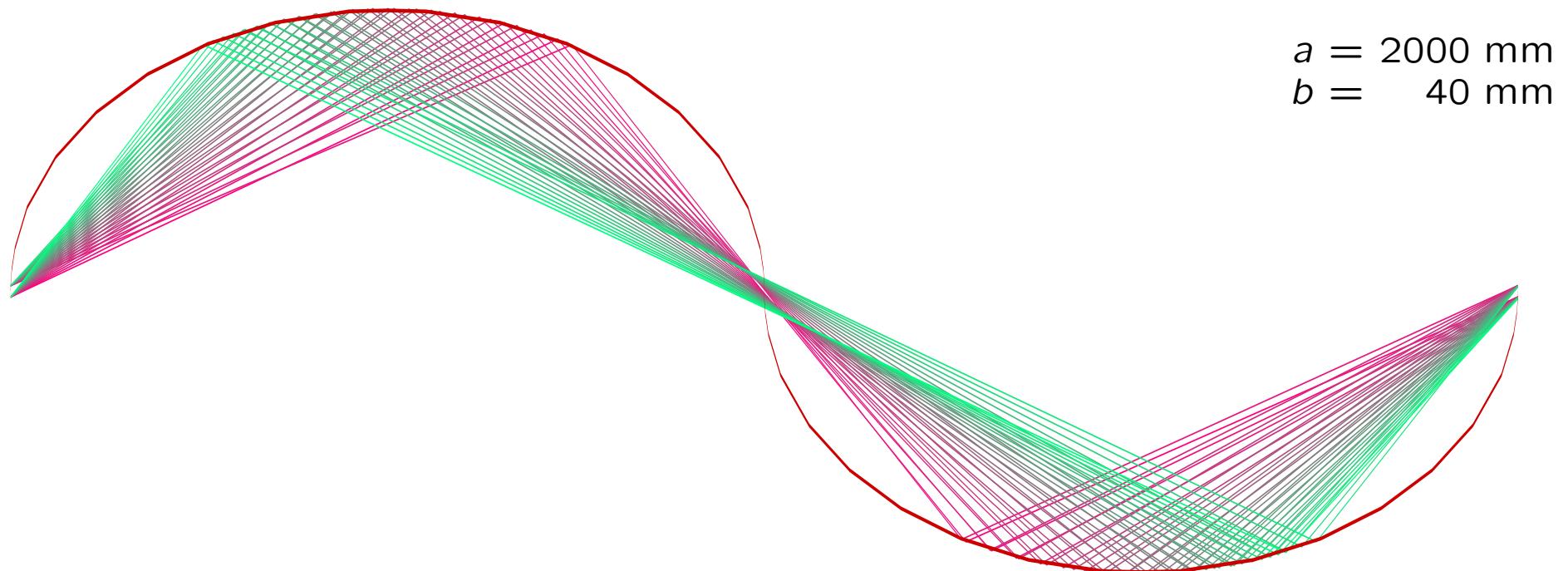


why two subsequent elliptic guides?

- convenient beam manipulation
 - guide dimensions not too large
- correction for coma aberration!

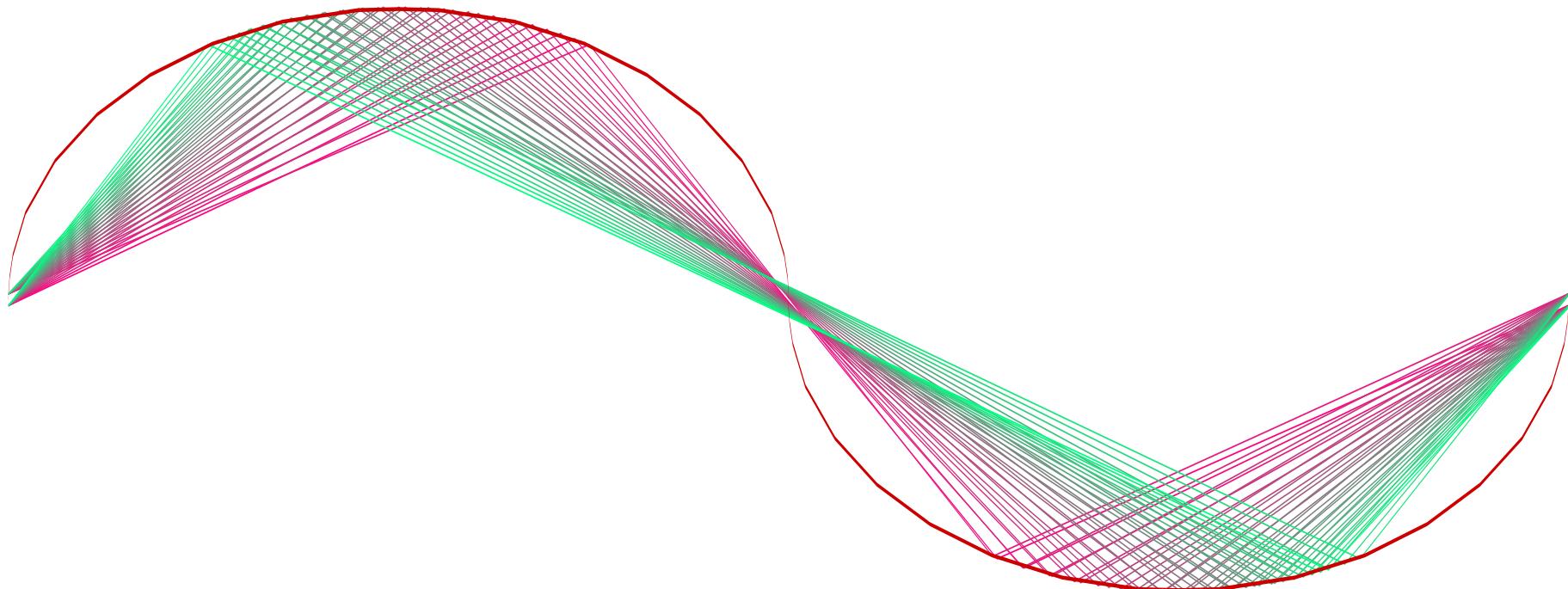
focusing with elliptic guides

coma aberration — and its correction



focusing with elliptic guides

coma aberration — and its correction



limitations:

- finite length of the guides
- non-perfect coating

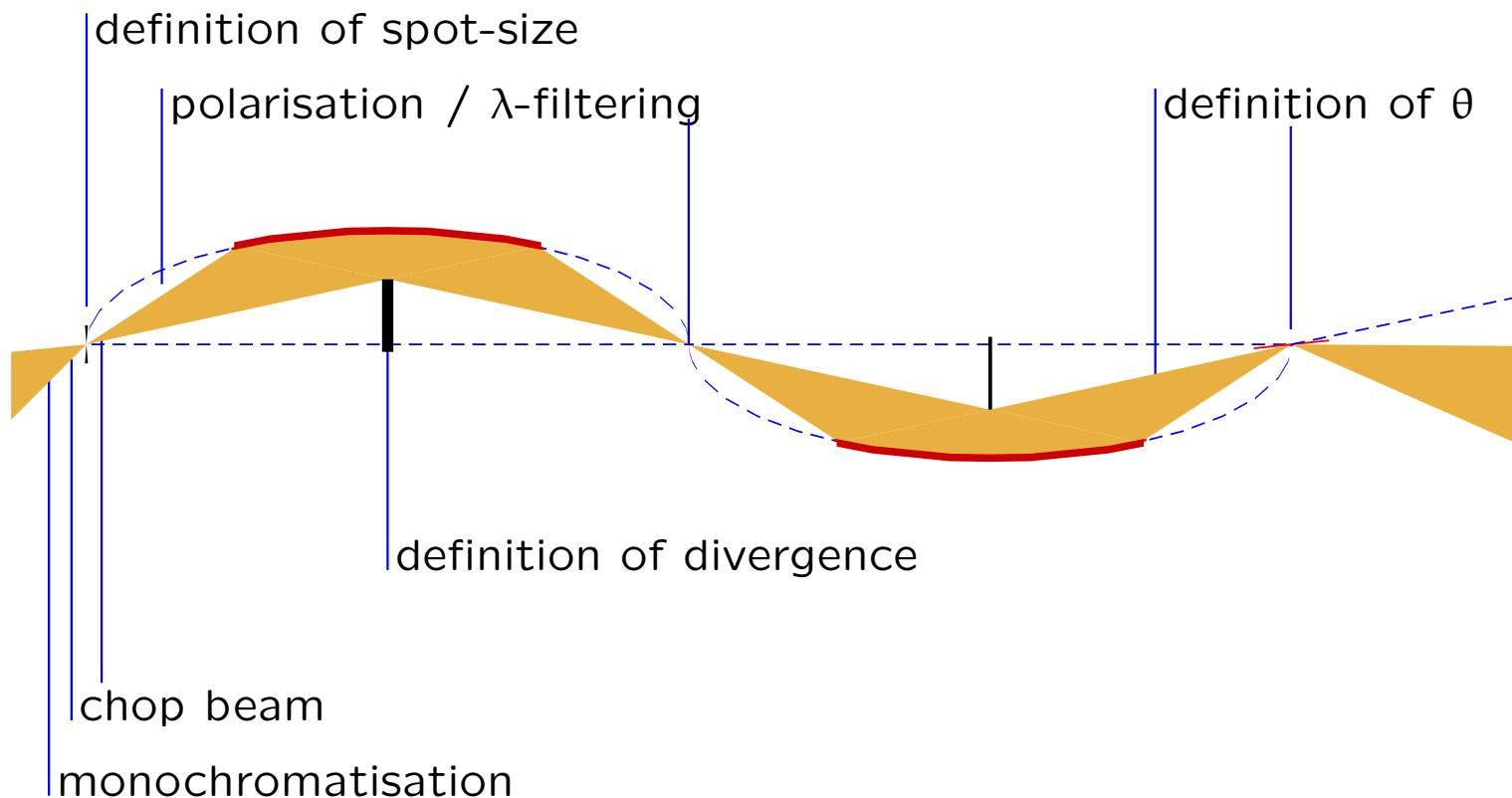
opportunities:

- use aberration to reduce beam spot or divergence at the sample

focusing with elliptic guides

operation modes for TOF:

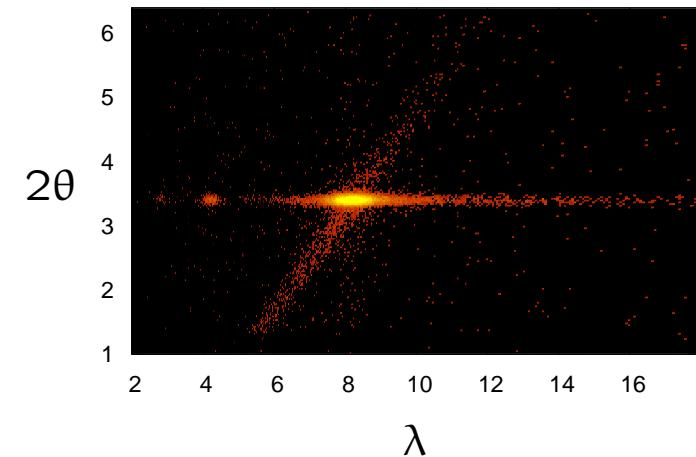
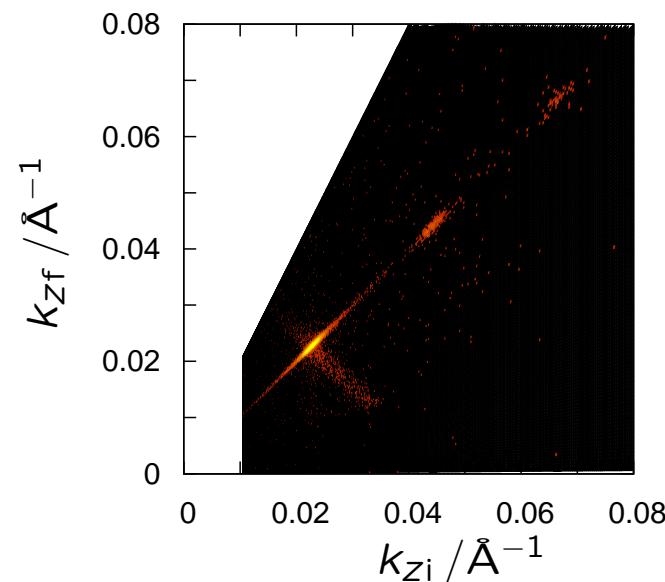
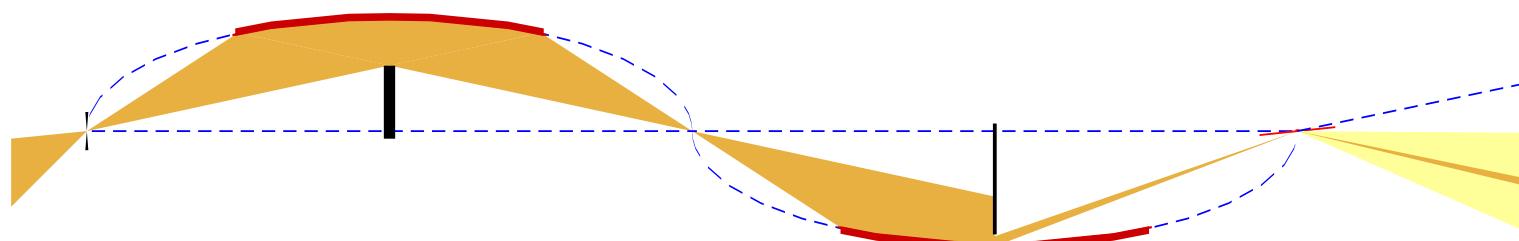
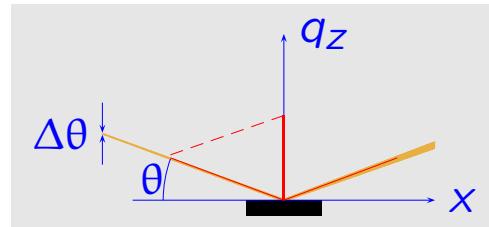
(non-TOF operation is also possible!)



focusing with elliptic guides

mode: almost conventional

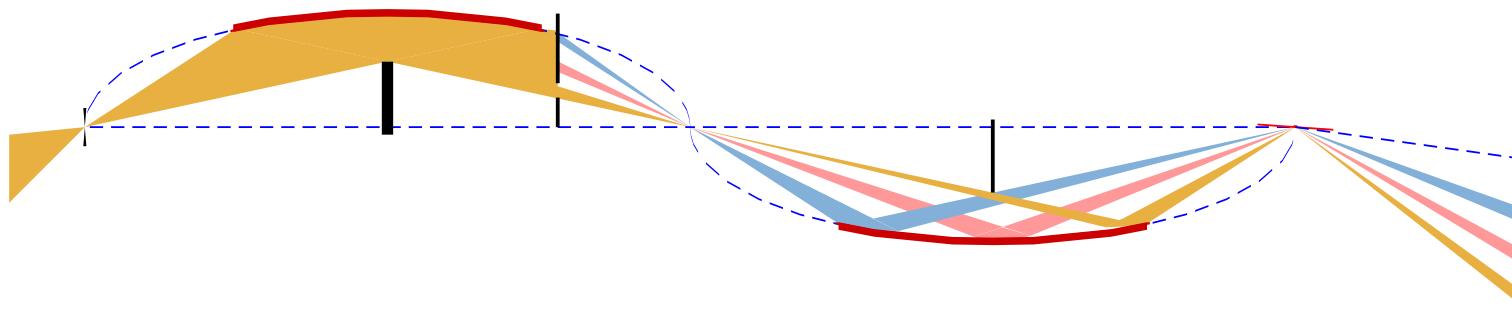
- beam is still convergent
- off-specular measurements are feasible



focusing with elliptic guides

mode: wide q -range

- vary θ with fixed sample position
- shift diaphragm (chopper) between pulses

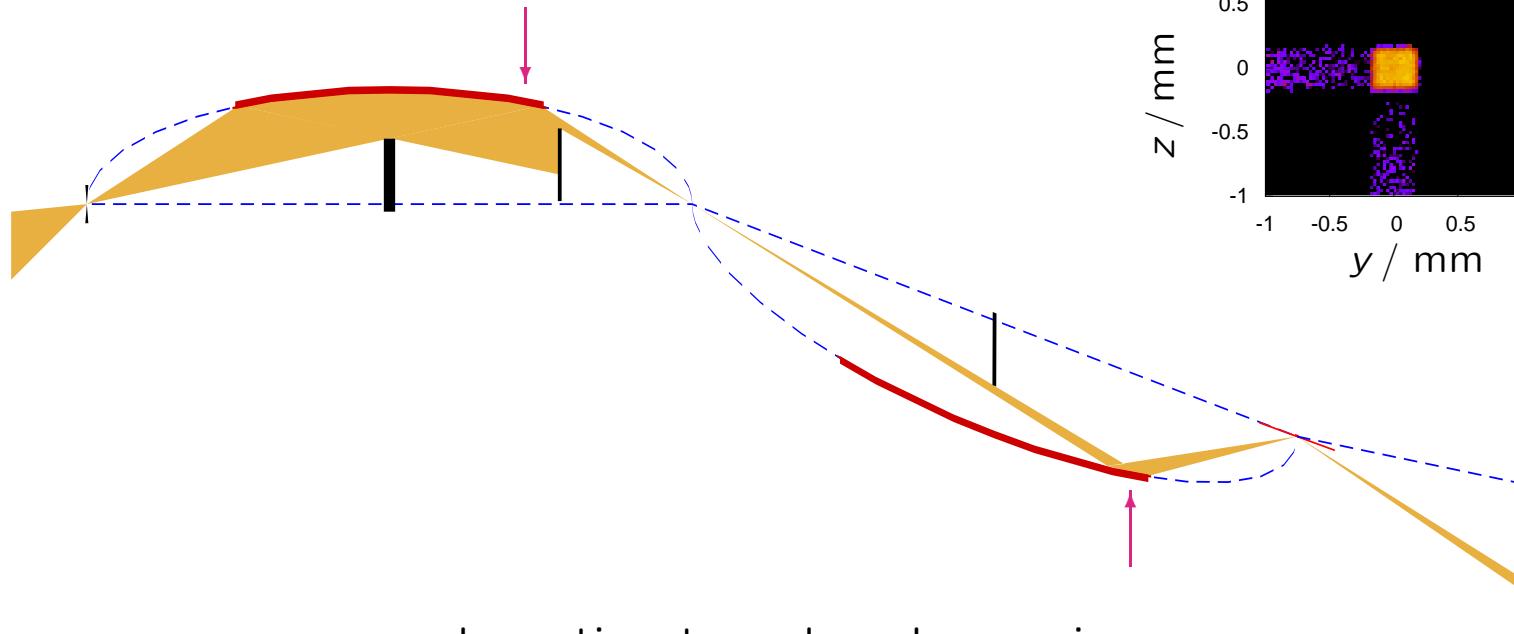


- suited for liquid surfaces

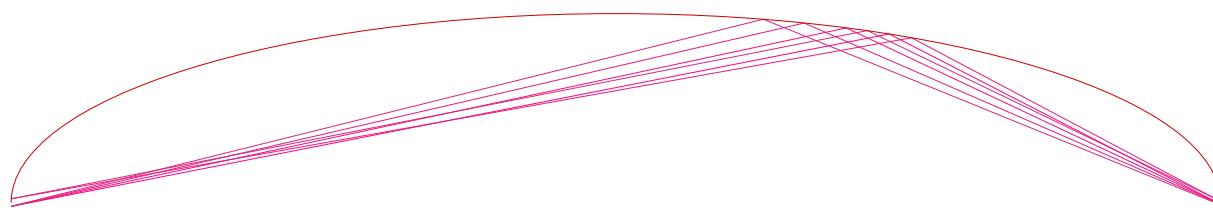
focusing with elliptic guides

mode: small spot size

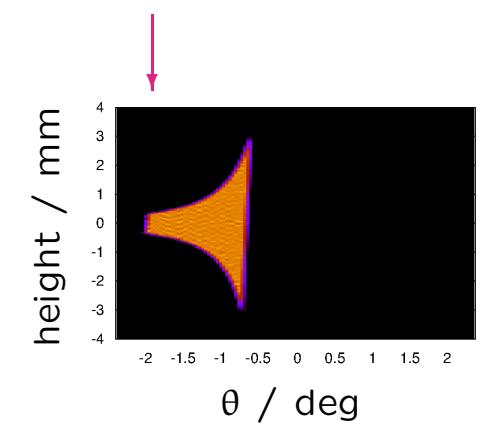
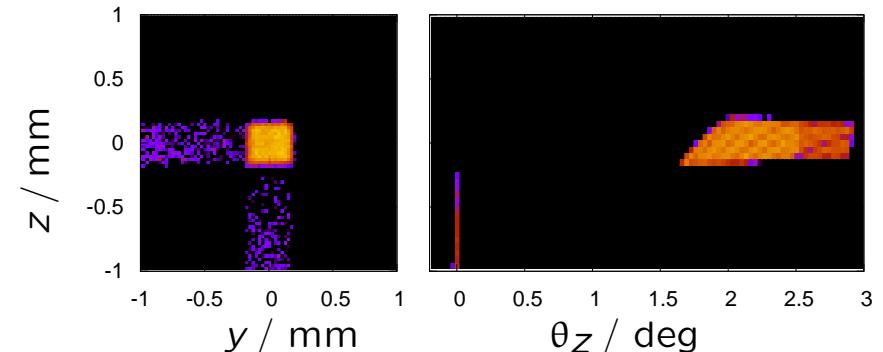
- uses focusing due to coma aberration
- scanning mode possible



use coma aberration to reduce beam size



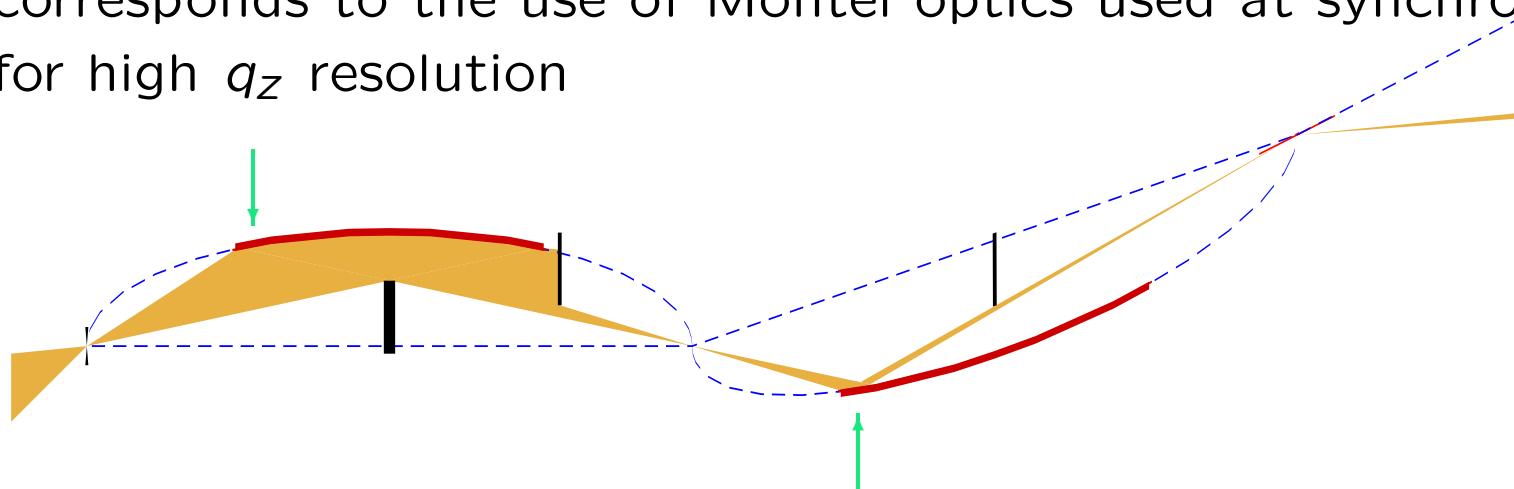
$I(y, z)$ and $I(z, \theta_z)$ at the sample
for a $1 \times 1 \text{ mm}^2$ entrance slit



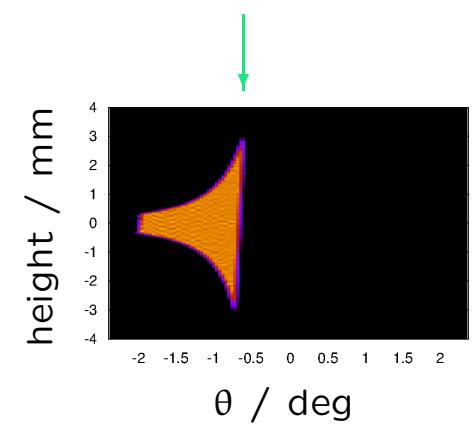
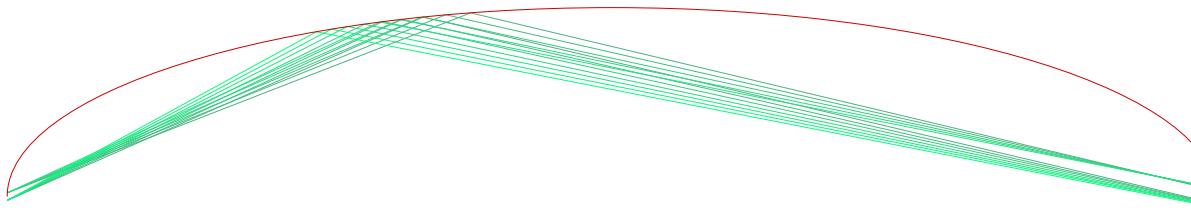
focusing with elliptic guides

mode: low-divergent beam

- uses defocusing due to coma aberration
- corresponds to the use of Montel optics used at synchrotrons
- for high q_z resolution



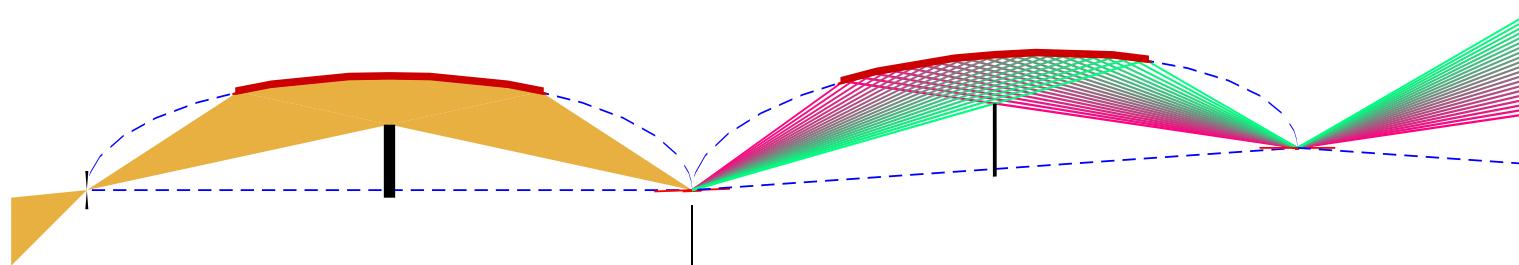
use coma aberration to reduce divergence



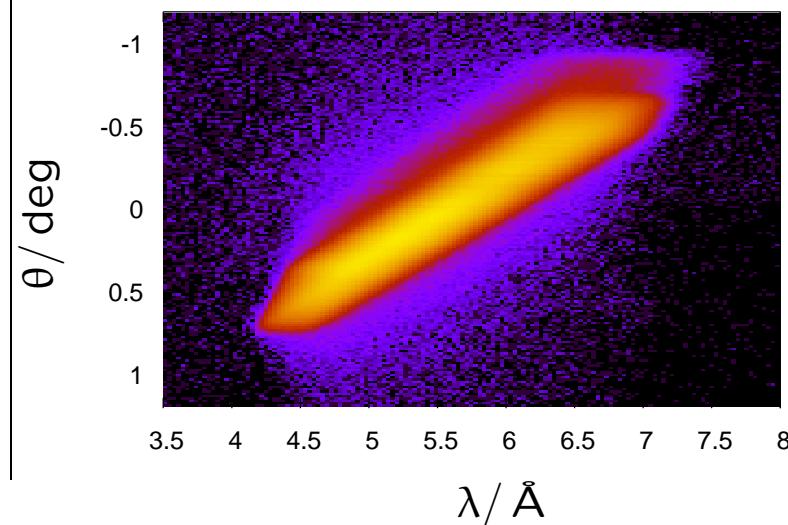
focusing with elliptic guides

mode: angle/energy encoding

- use a ml-monochromator at the intermediate image
- spectral analysis of the beam: λ / θ encoding



$\log_{10} [I(\lambda, \theta)]$ after ml monochromator

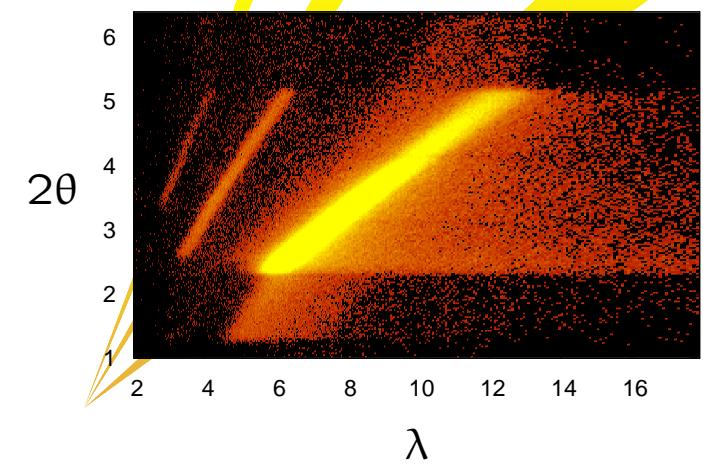
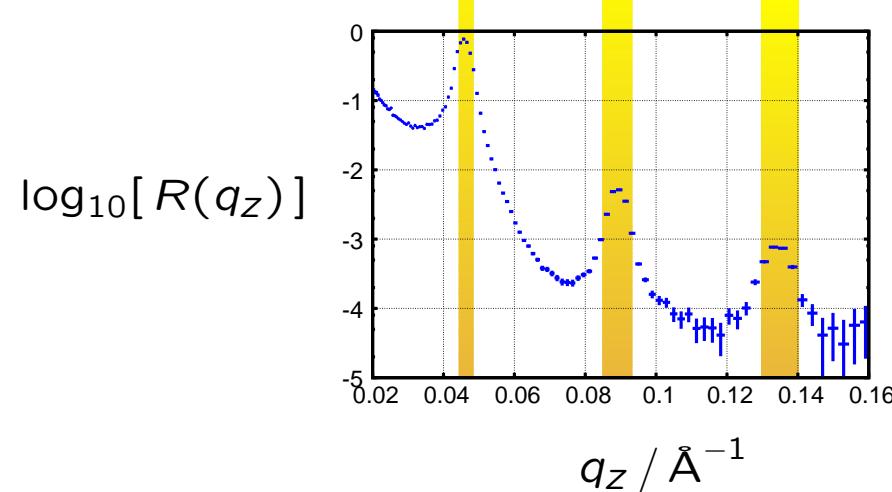
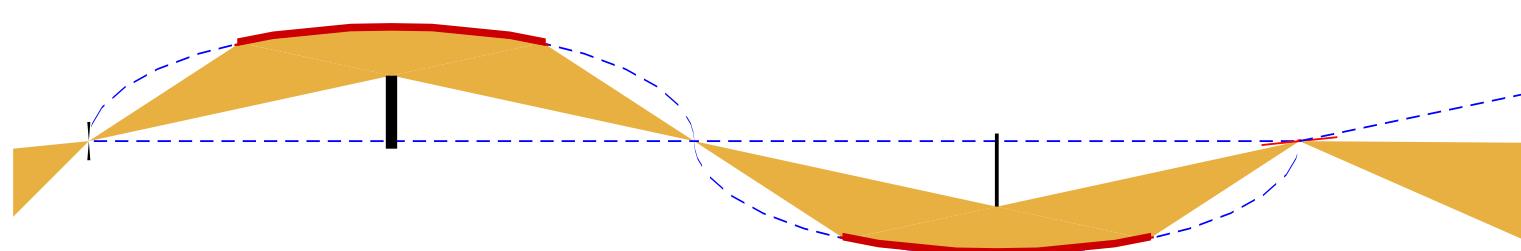
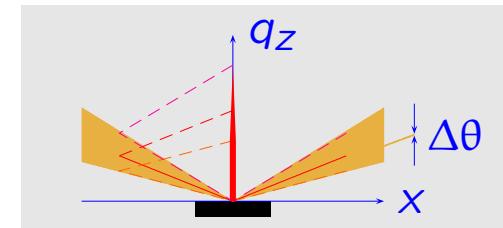


- large λ on small θ
 \Rightarrow wide q_z -range

focusing with elliptic guides

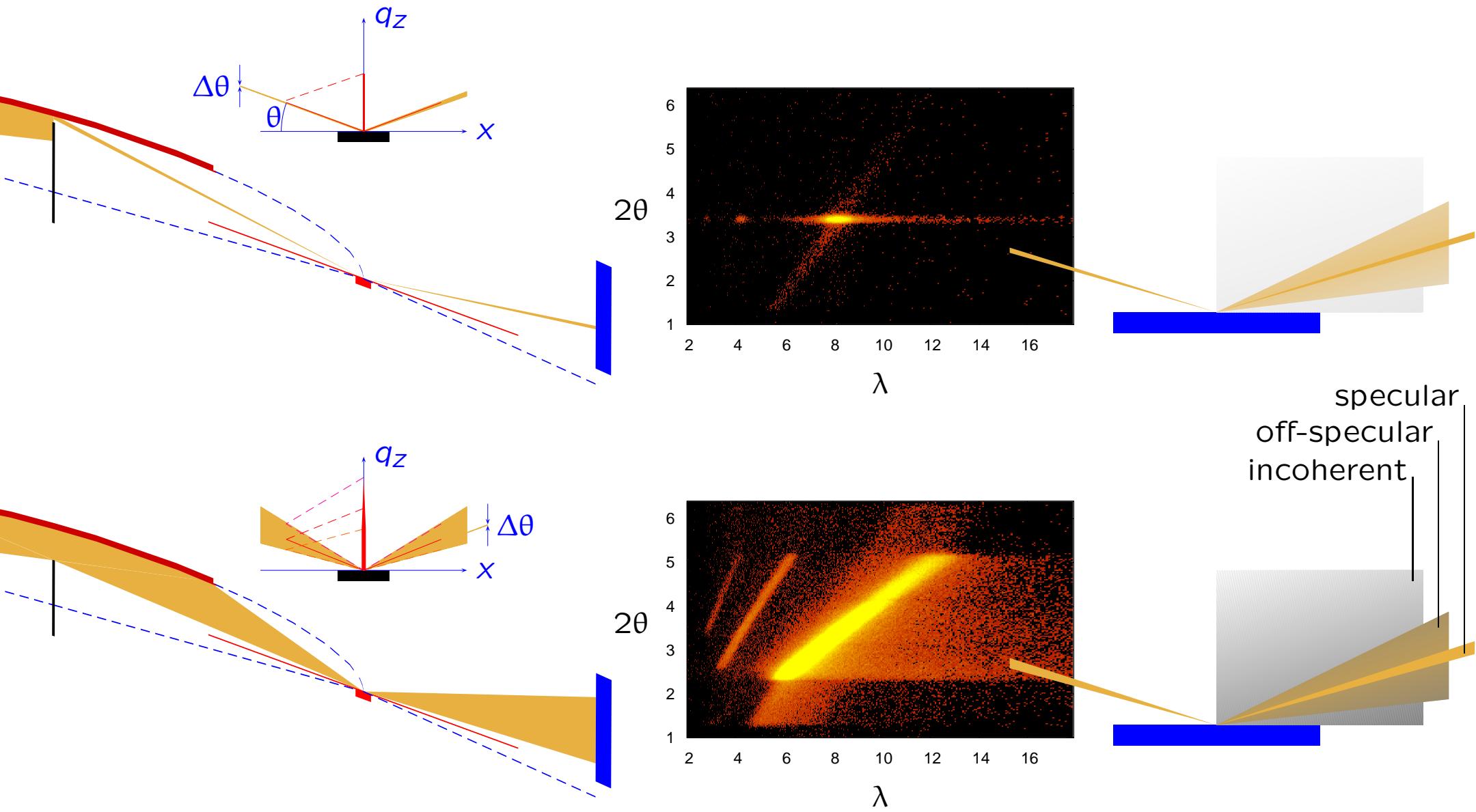
mode: high-intensity specular reflectivity

- energy- and angle-dispersive \Rightarrow gain > 10
- for fast scanning ($T, H, E \dots$)
- or if off-specular scattering is no problem



focusing with elliptic guides

high-intensity specular reflectivity vs. almost conventional



realisation

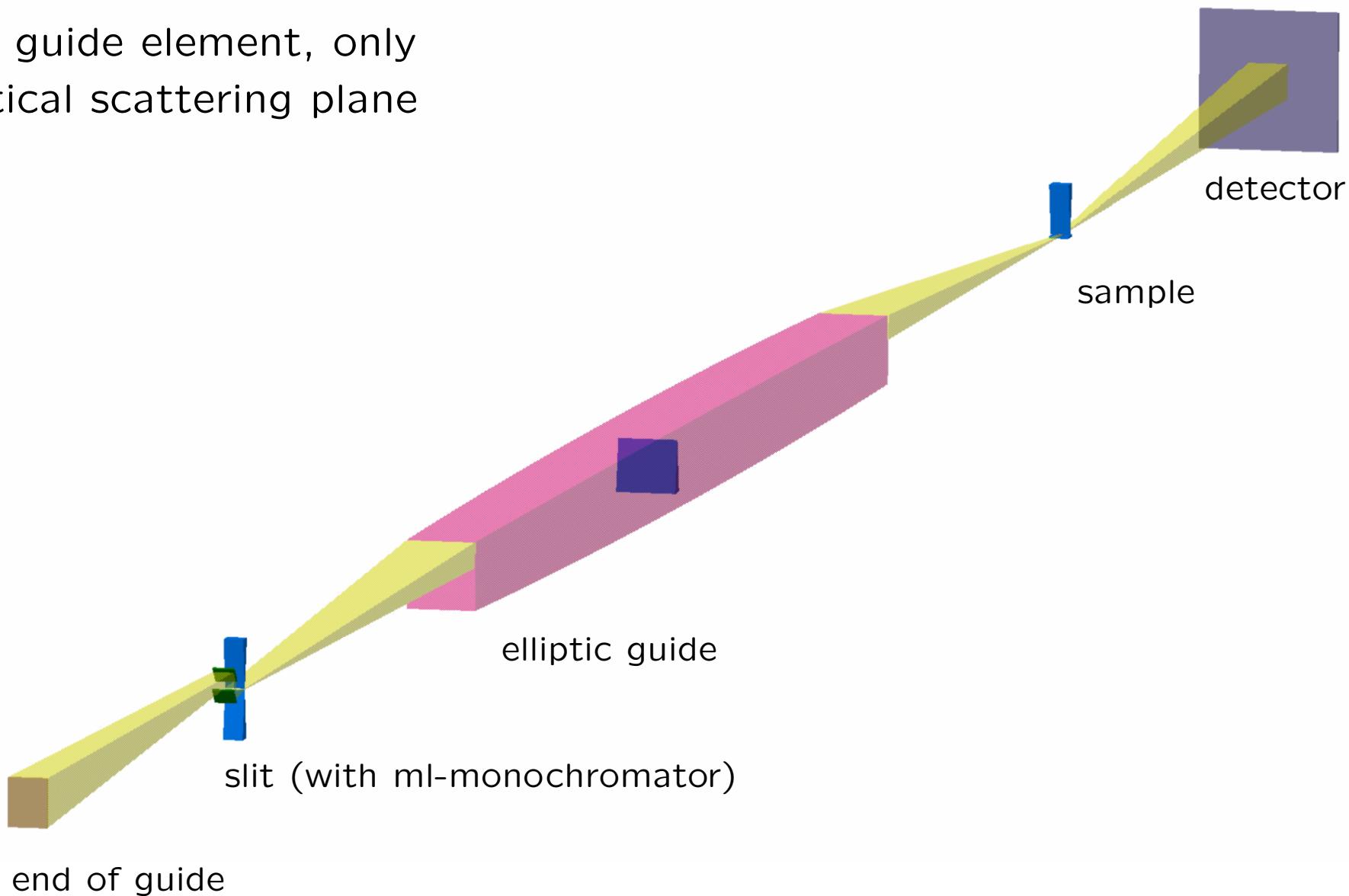
add-on for Amor

prototype on BOA

concept for the ESS

realisation: add-on for Amor

one guide element, only
vertical scattering plane



realisation: add-on for Amor

Amor, conventional TOF set-up

8 m granite block

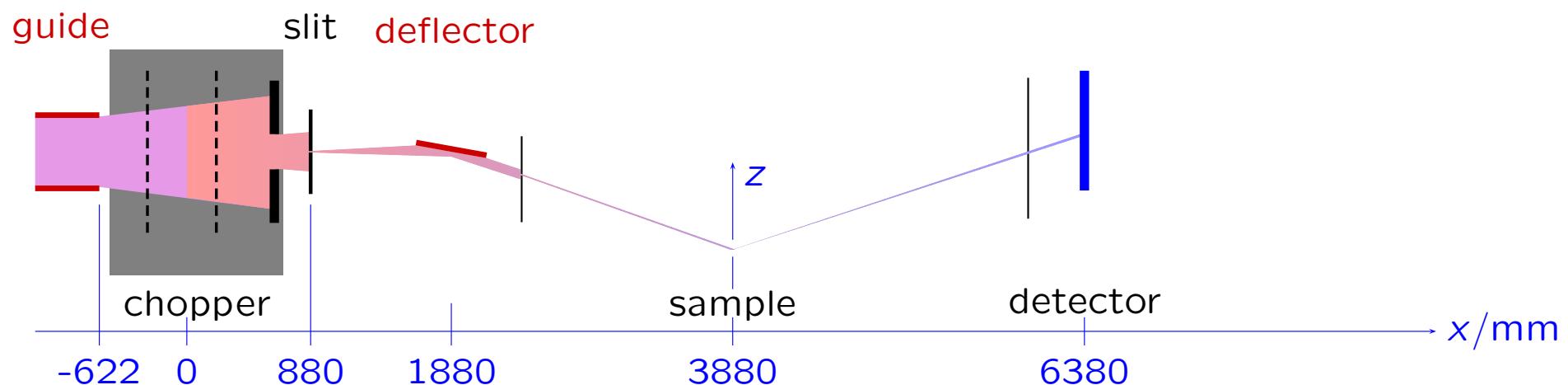
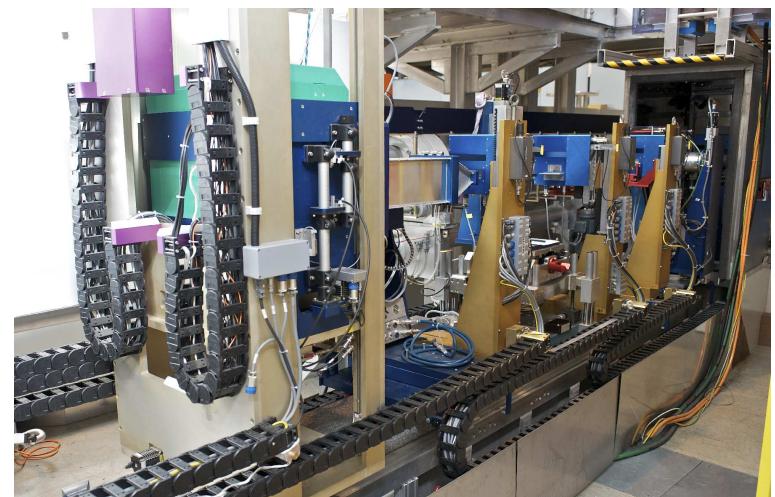
maximum length chopper to detector = 10 m

$2\theta \in [-3^\circ, 12^\circ]$

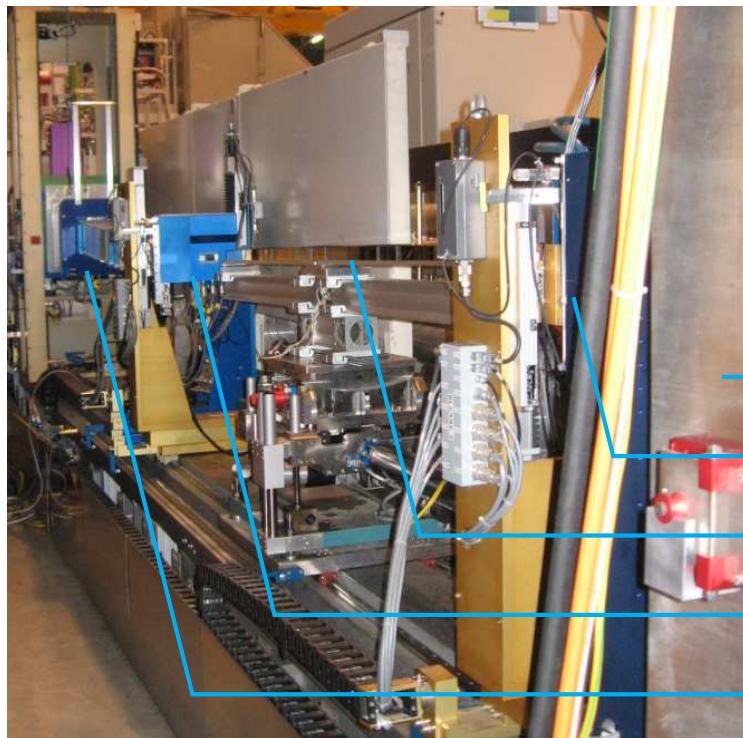
$\lambda \in [2 \text{ \AA}, 18 \text{ \AA}]$

vertical scattering plane

detectors: ${}^3\text{He}$ single and area ($180 \times 180 \text{ mm}^2$)



realisation: add-on for Amor



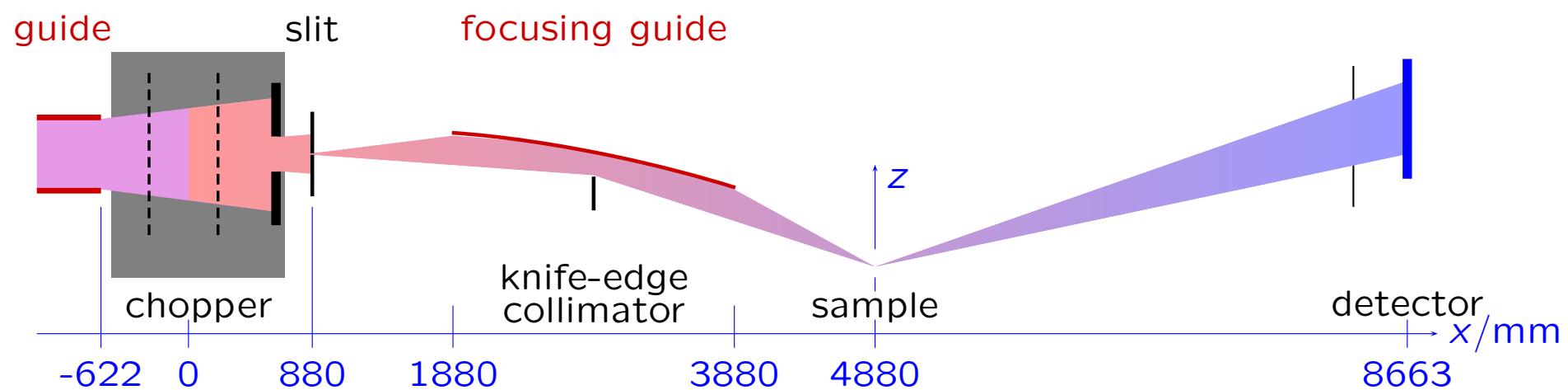
chopper housing

1st slit

elliptic reflector (SwissNeutronics)

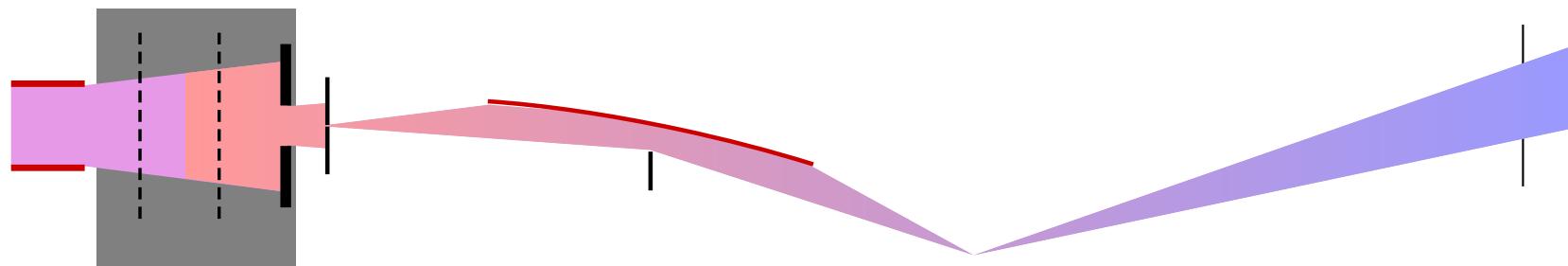
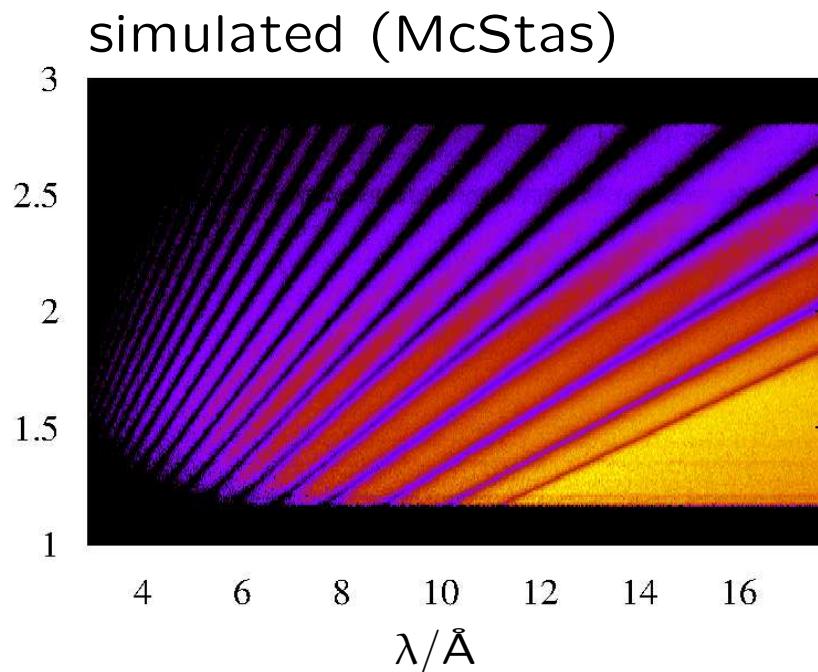
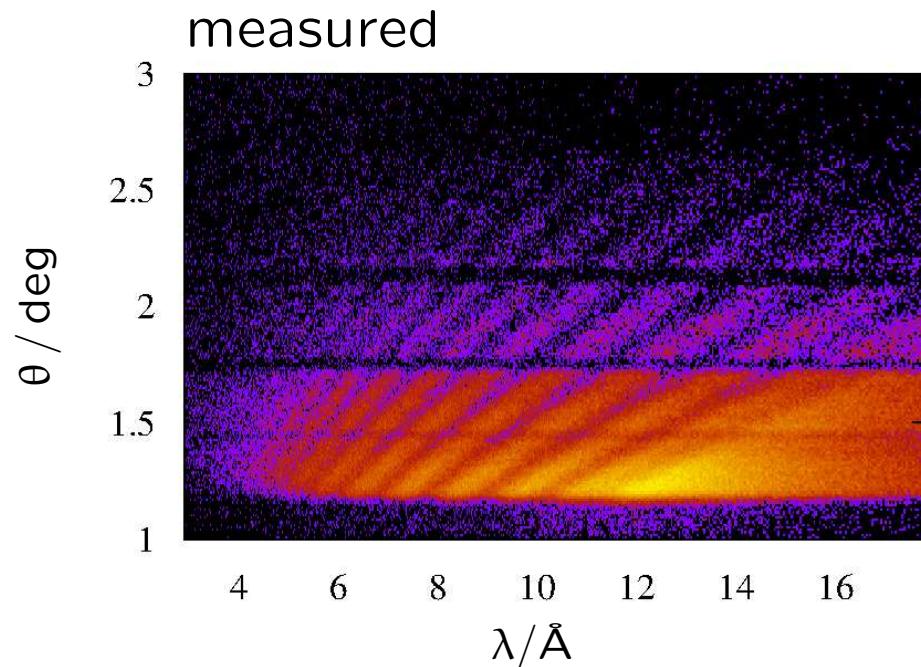
sample (hidden by diaphragm)

detector



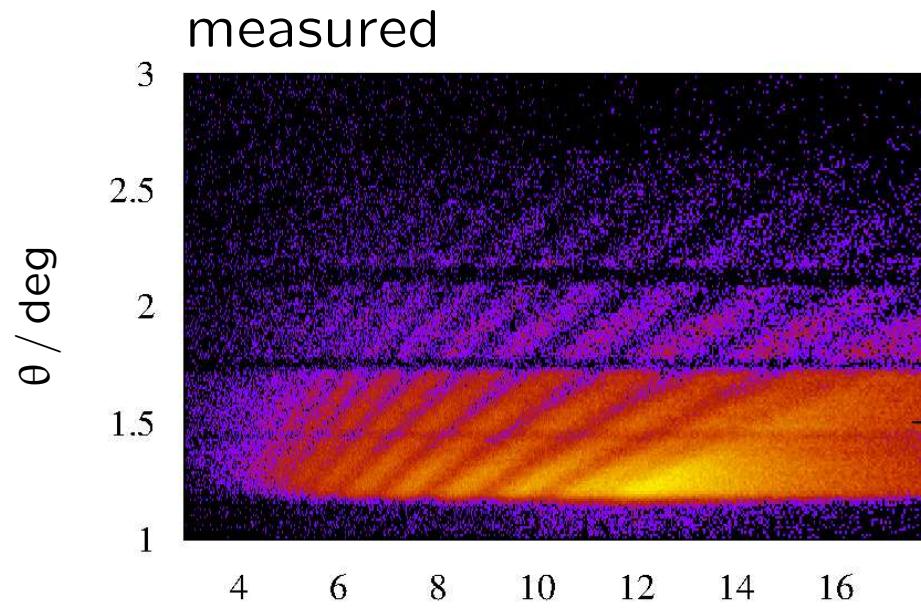
realisation: add-on for Amor

measurements: 1000 Å Ni film on glass, $9 \times 9 \text{ mm}^2$

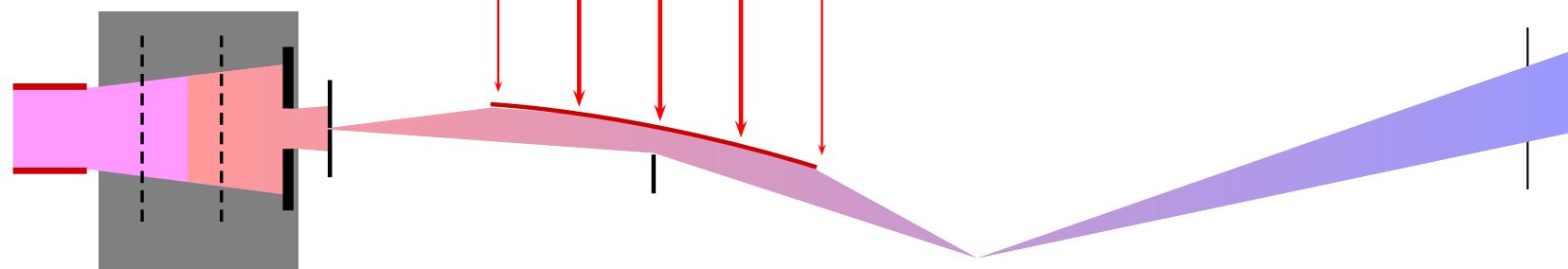
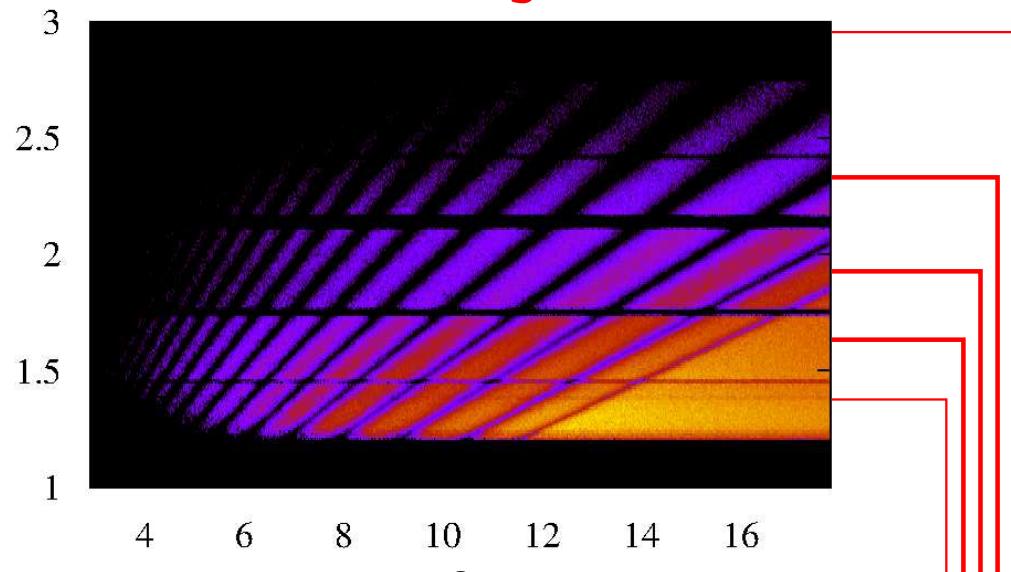


realisation: add-on for Amor

measurements: 1000 Å Ni film on glass, $9 \times 9 \text{ mm}^2$

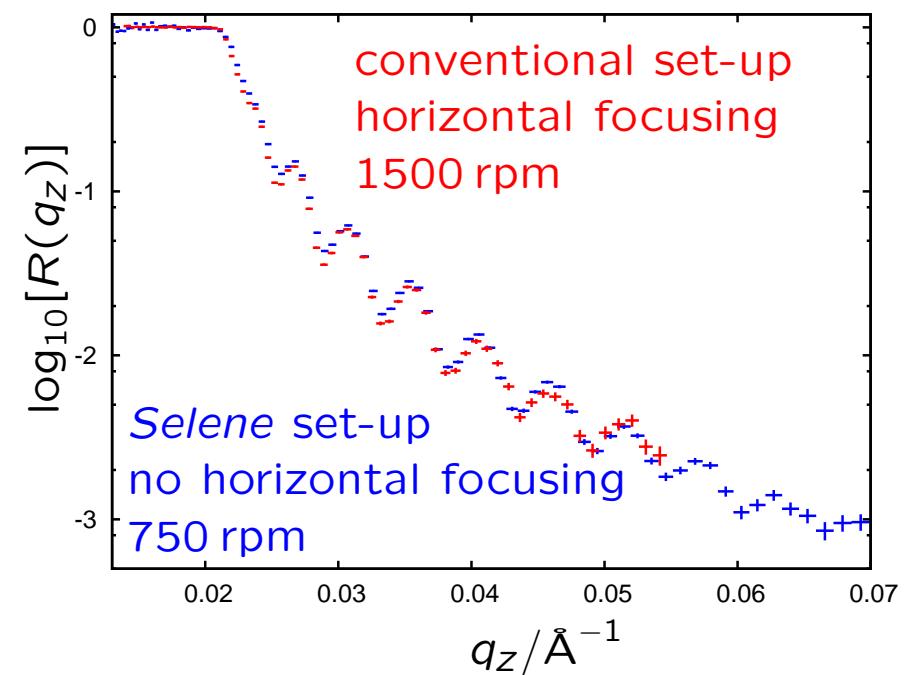
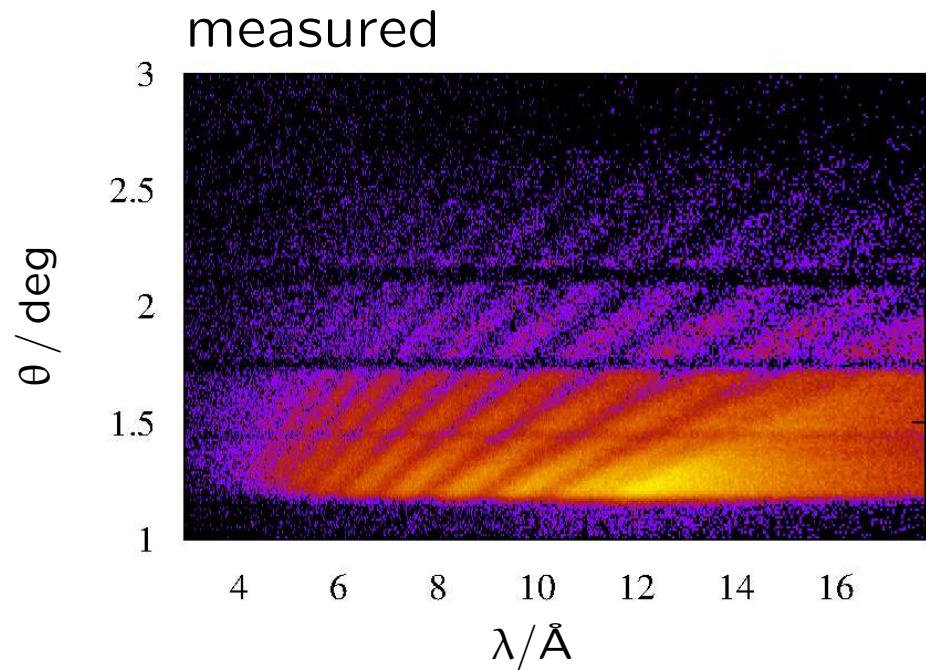


simulated with geometrical errors



realisation: add-on for Amor

measurements: 1000 Å Ni film on glass, $9 \times 9 \text{ mm}^2$



measurement time:

conventional	5 h
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Selene	45 min
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gain-factor 6.7

realisation: add-on for Amor

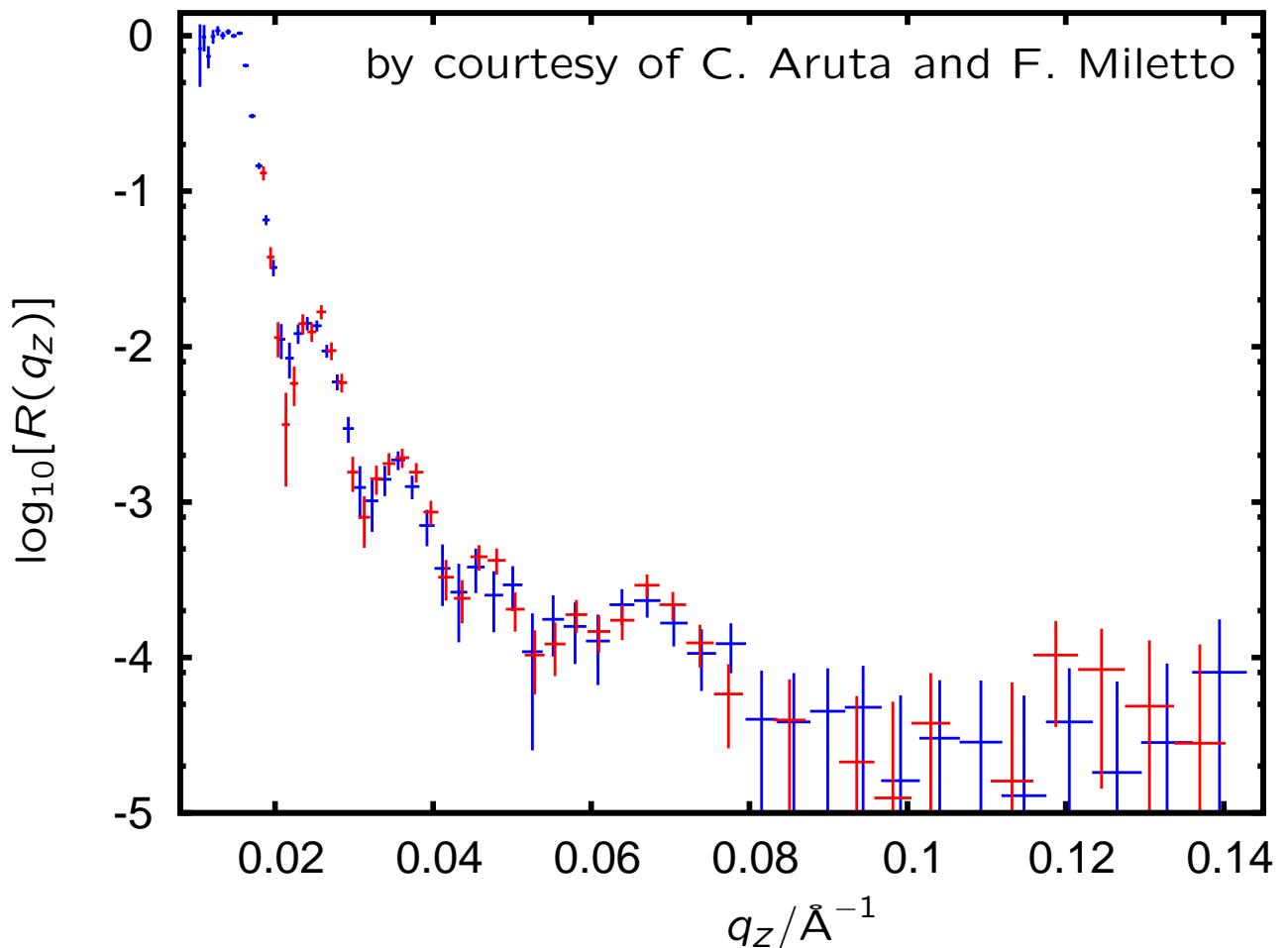
$[\text{La}_{2/3}\text{Sr}_{1/3}\text{MnO}_3 / \text{SrTiO}_3]_4 / \text{NGO}$

$5 \times 5 \text{ mm}^2$

- no focusing in sample plane
- TOF mode, $\lambda \in [2 \dots 18 \text{ \AA}]$
- measurement time:

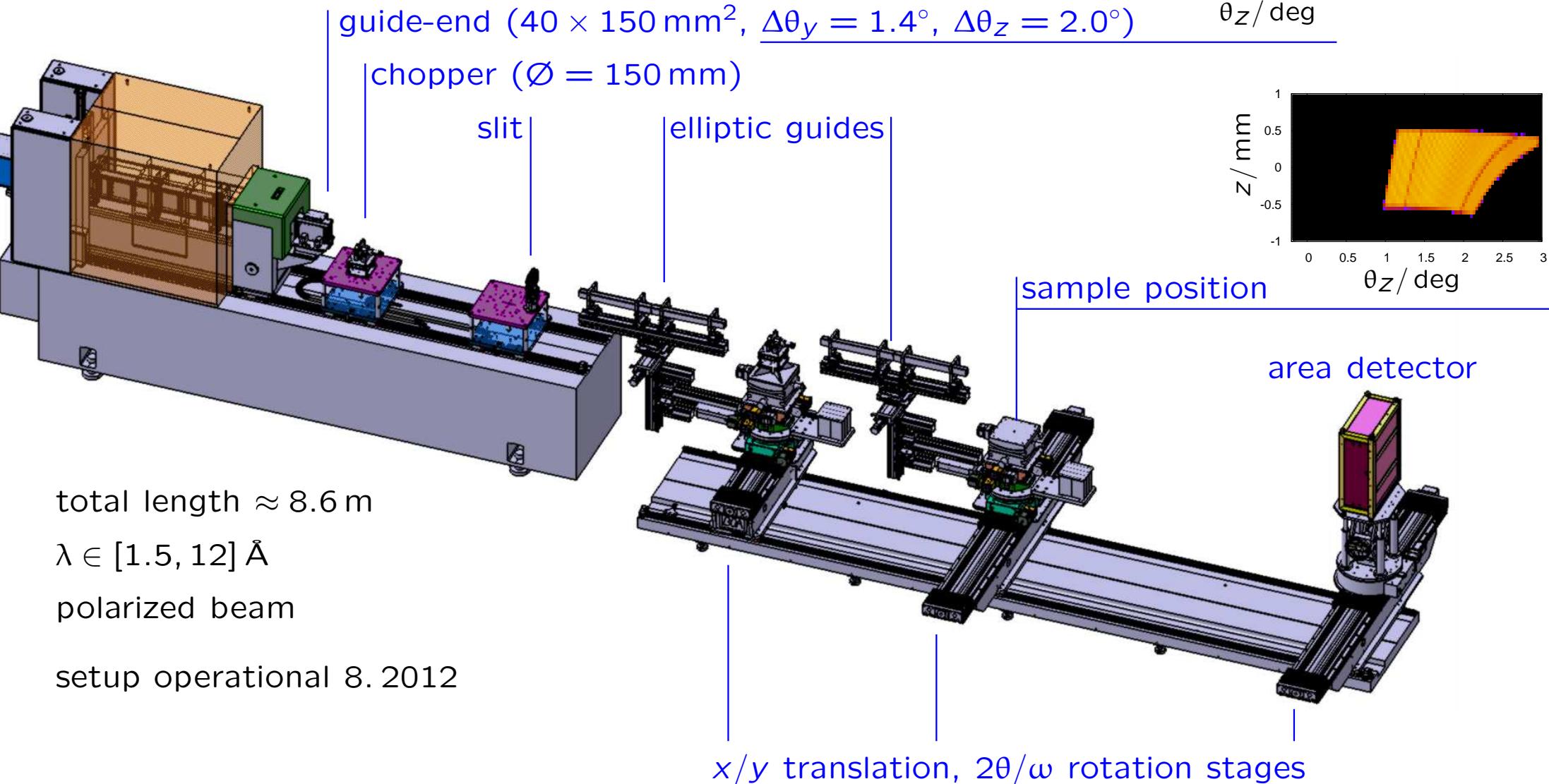
conventional	<u>6.5 h</u>
<i>Selene</i>	<u>45 min</u>

gain-factor 8.3



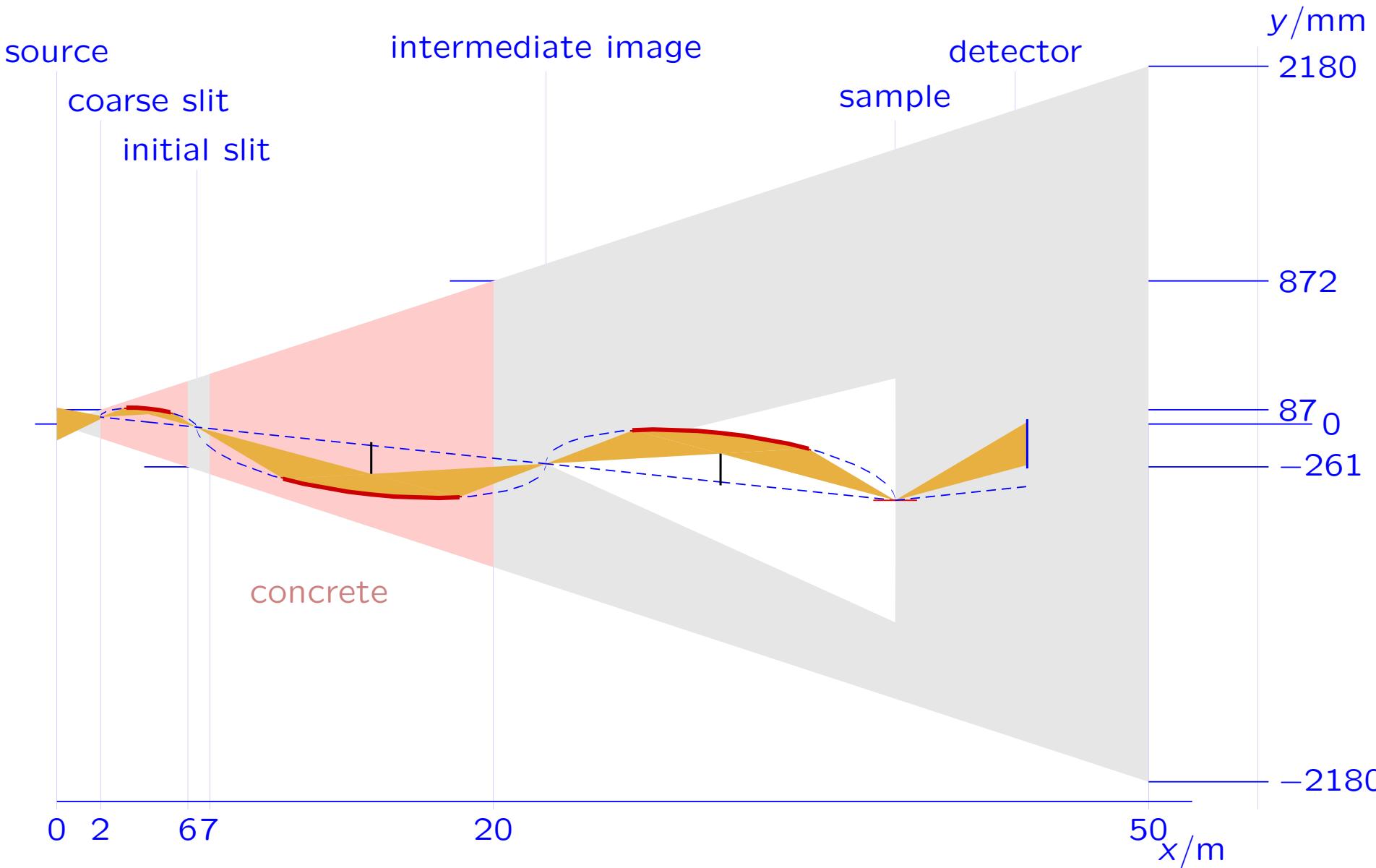
realisation: prototype on BOA

BOA is a test beam line at SINQ, PSI

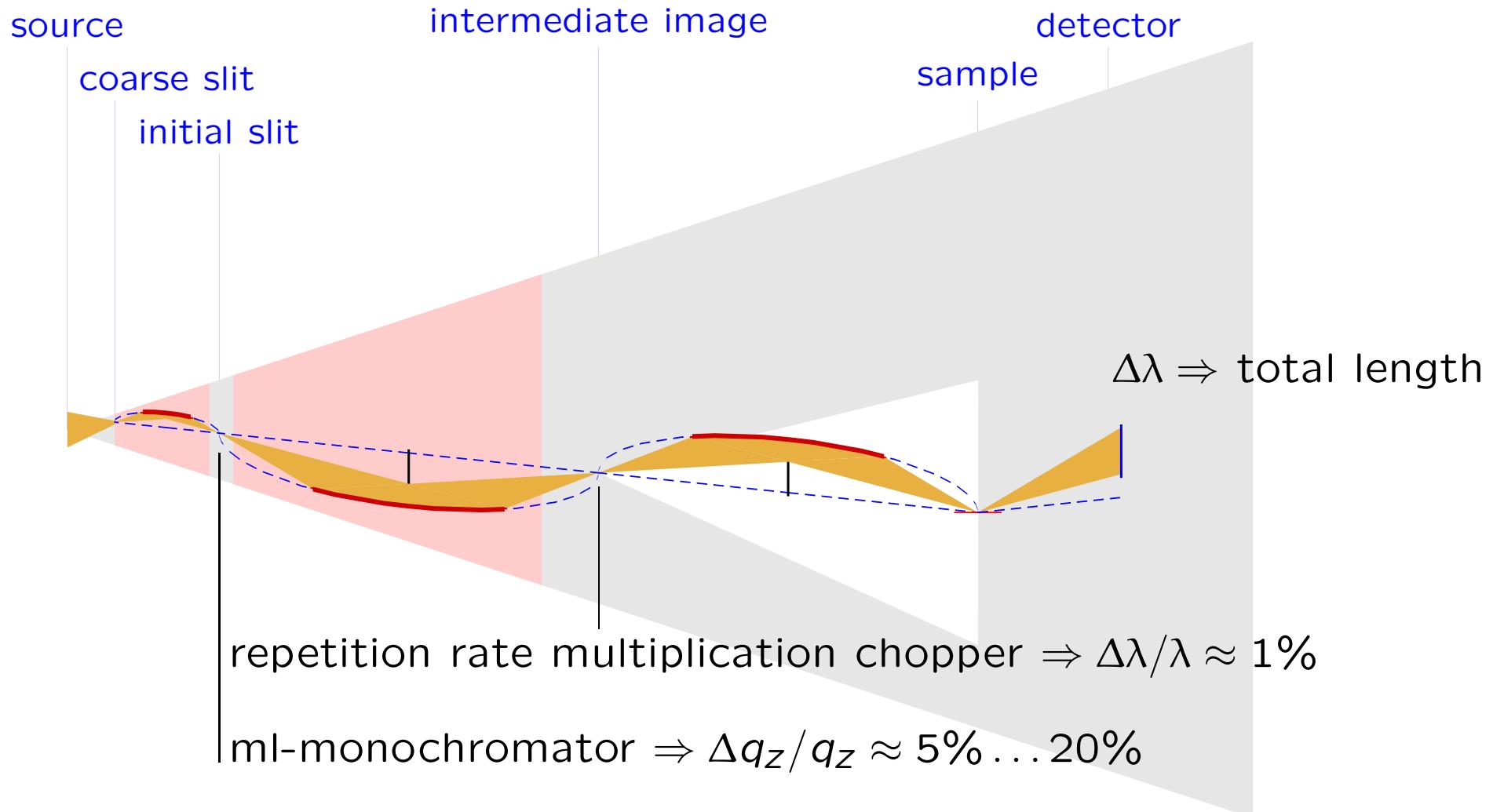


realisation: concept for the ESS

schematic lay-out of the reflectometer for tiny samples



realisation: concept for the ESS

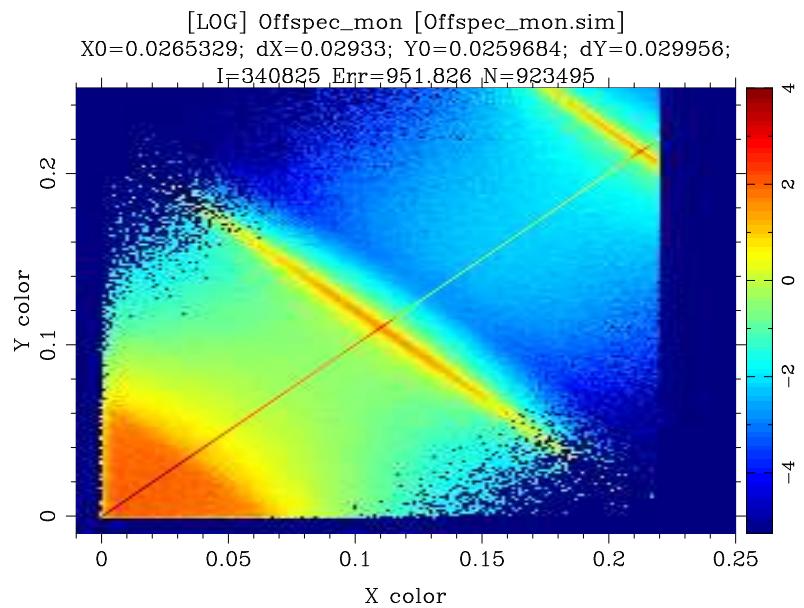


final remarks

critical points

- accuracy of guides
 - how to assemble the 0.5 m units without errors
- alignment of guides
- scattering at focal points
 - from diaphragms / choppers
 - off-specular form mirrors

first simulation with off-specular
scattering with McStas
(K. Leffman, 12. 2011)



- influence of gravity
 - will be simulated within the next months

thanks to

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Marité Cardenas experiments
Anette Vickery

Hanna Wacklin discussions
Bob Cubitt
Peter Böni
Uwe Stuhr
Frederic Ott
Thomas Krist

Selene is a guide concept

which . . .

- prevents direct line of sight
 - reduces radiation in the guide
 - allows for convenient beam manipulation
 - reduces illumination of the sample environment
 - allows for a convergent beam set-up
⇒ flux gain > 10



URL: <http://people.web.psi.ch/stahn>

J. Stahn, et al. N.I.M. A 634, S12 (2011)

J. Stahn, et al. Eur. Phys. J. Appl. Phys., doi:10.1051/epjap/2012110295